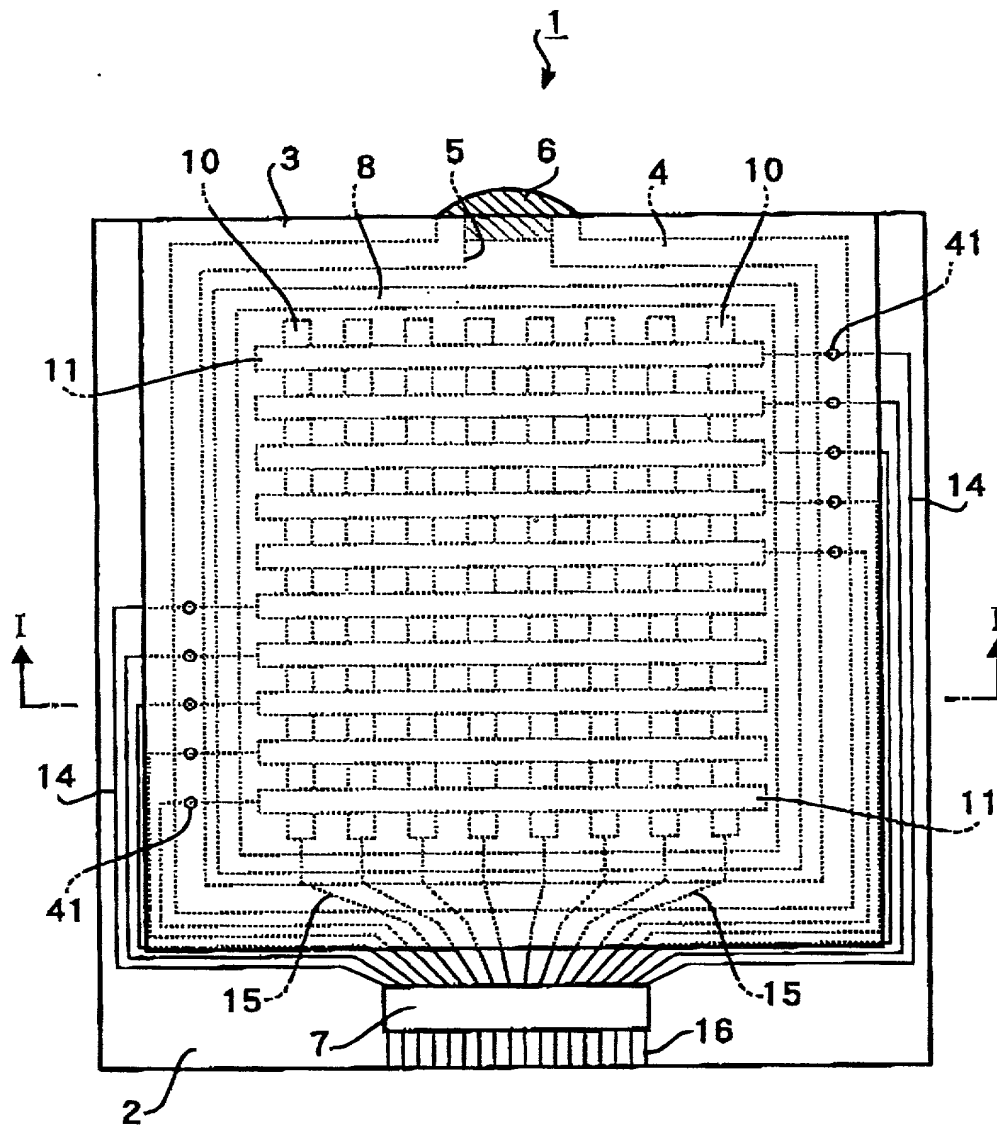


FIG. 1



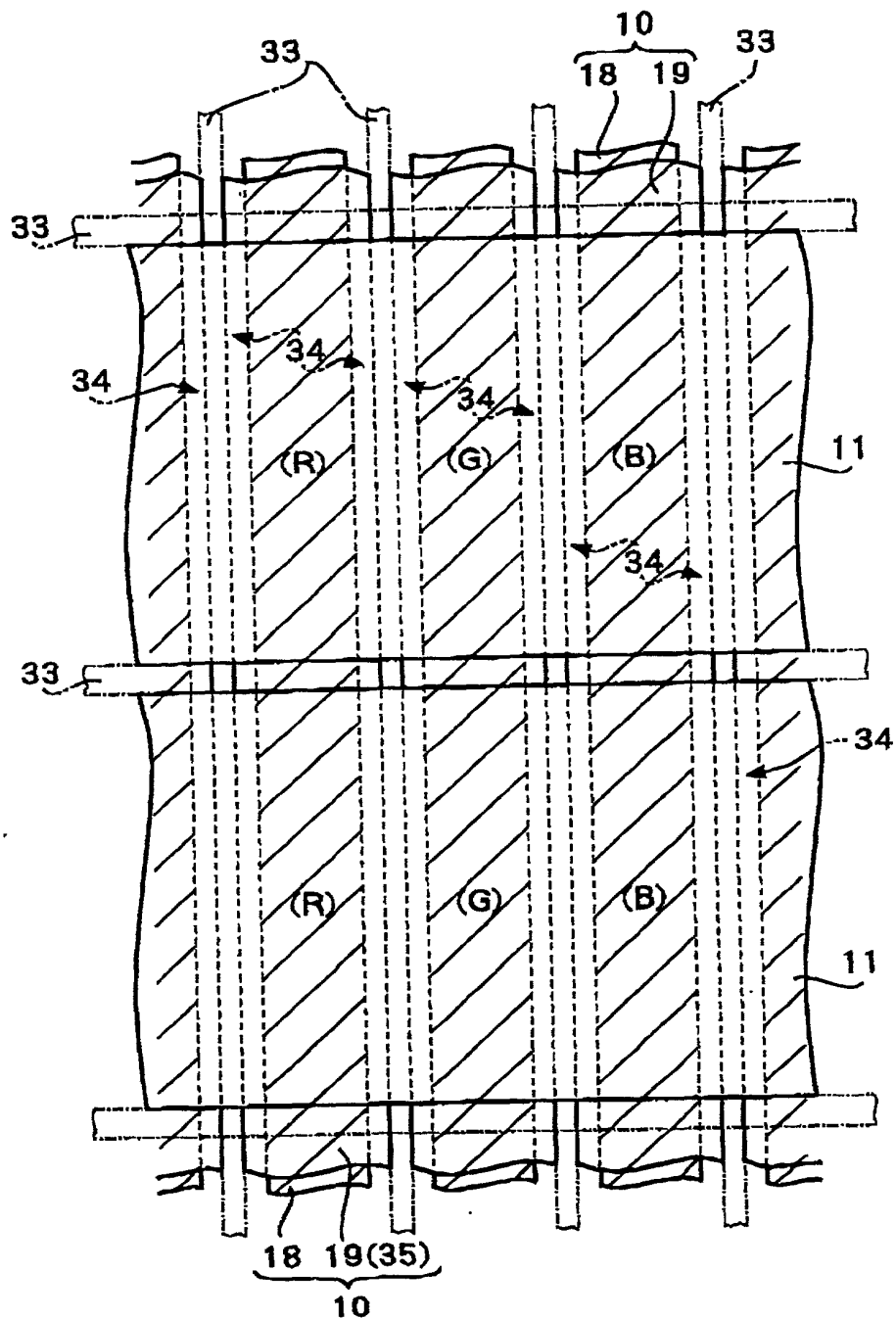
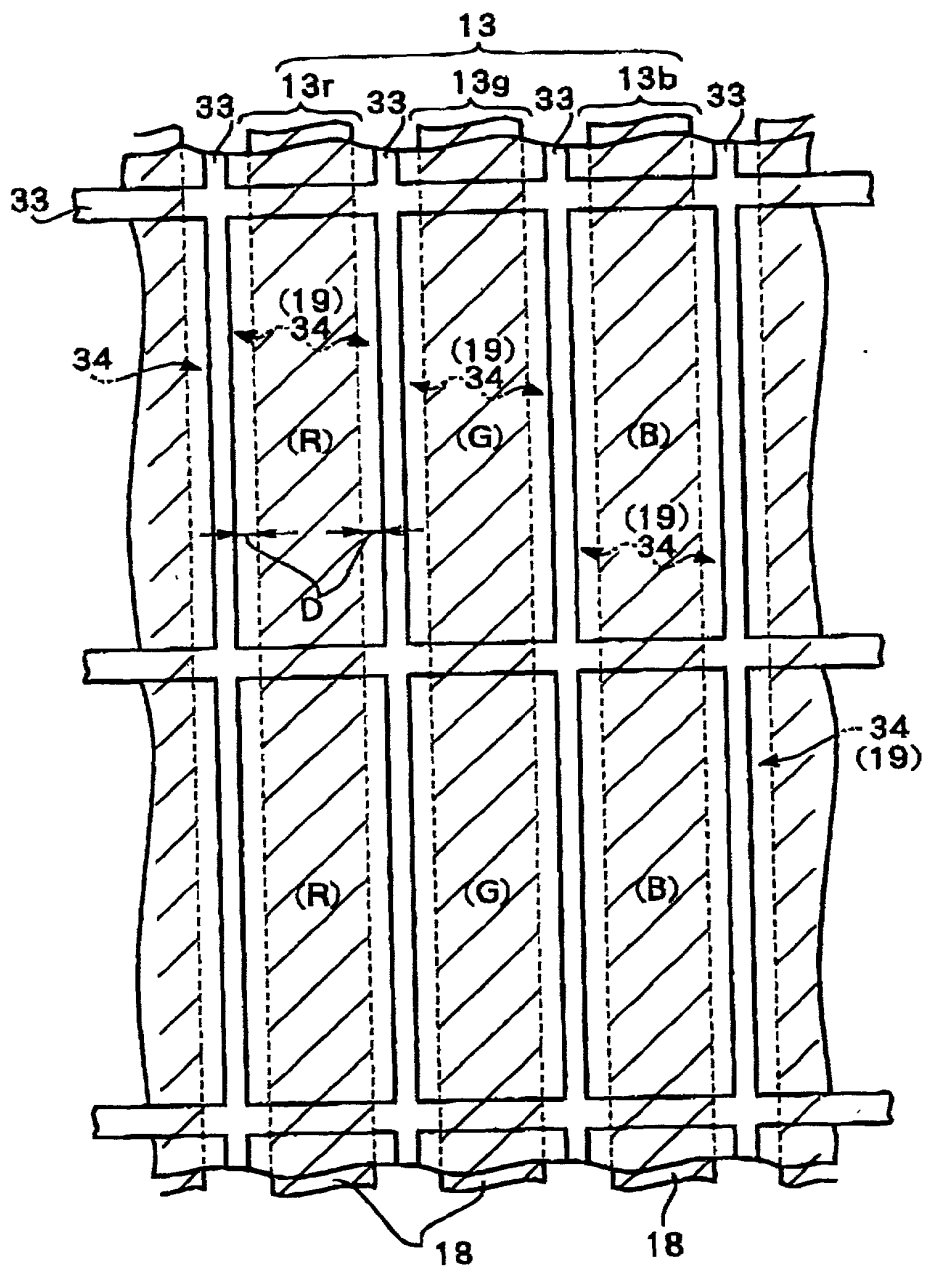
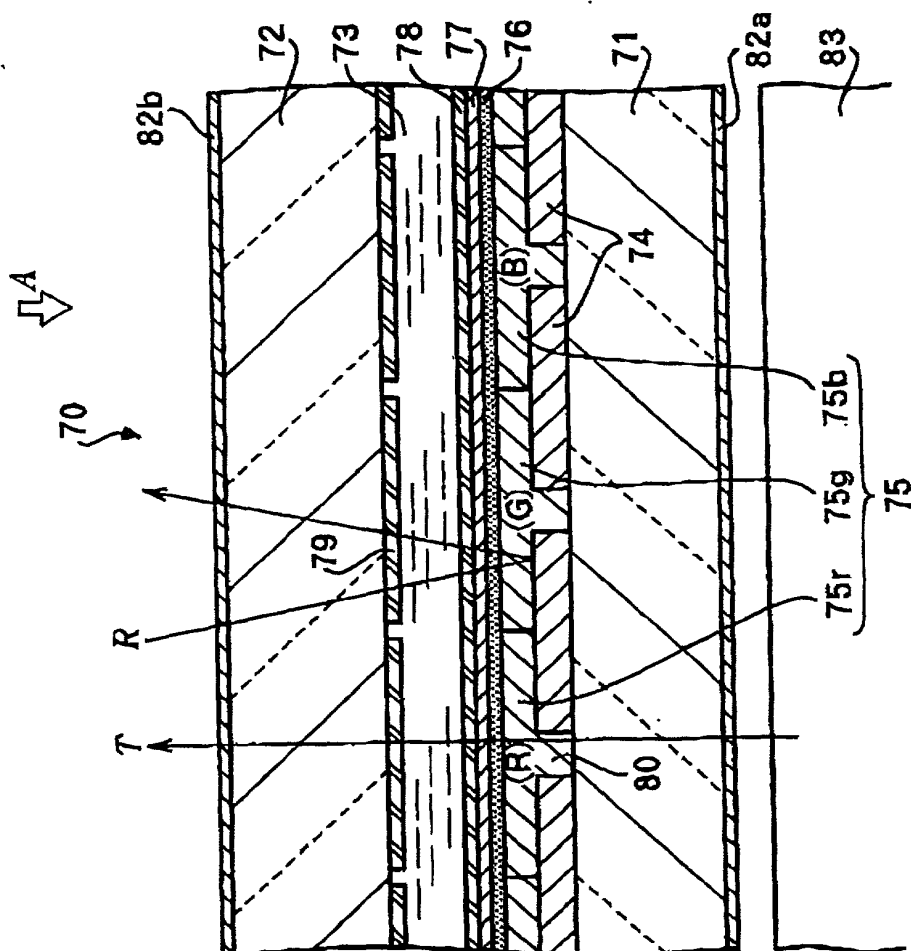


FIG. 4



PRIOR ART



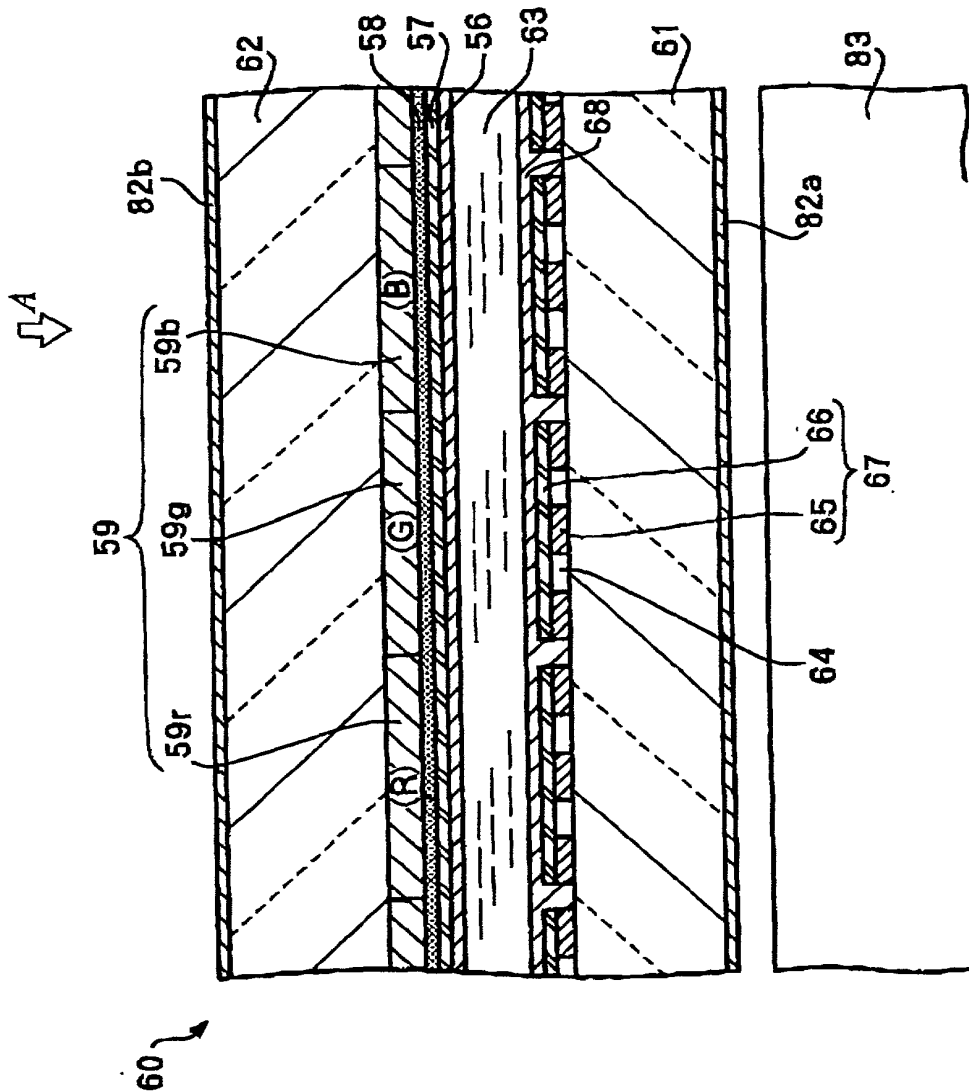


FIG. 8

PRIOR ART

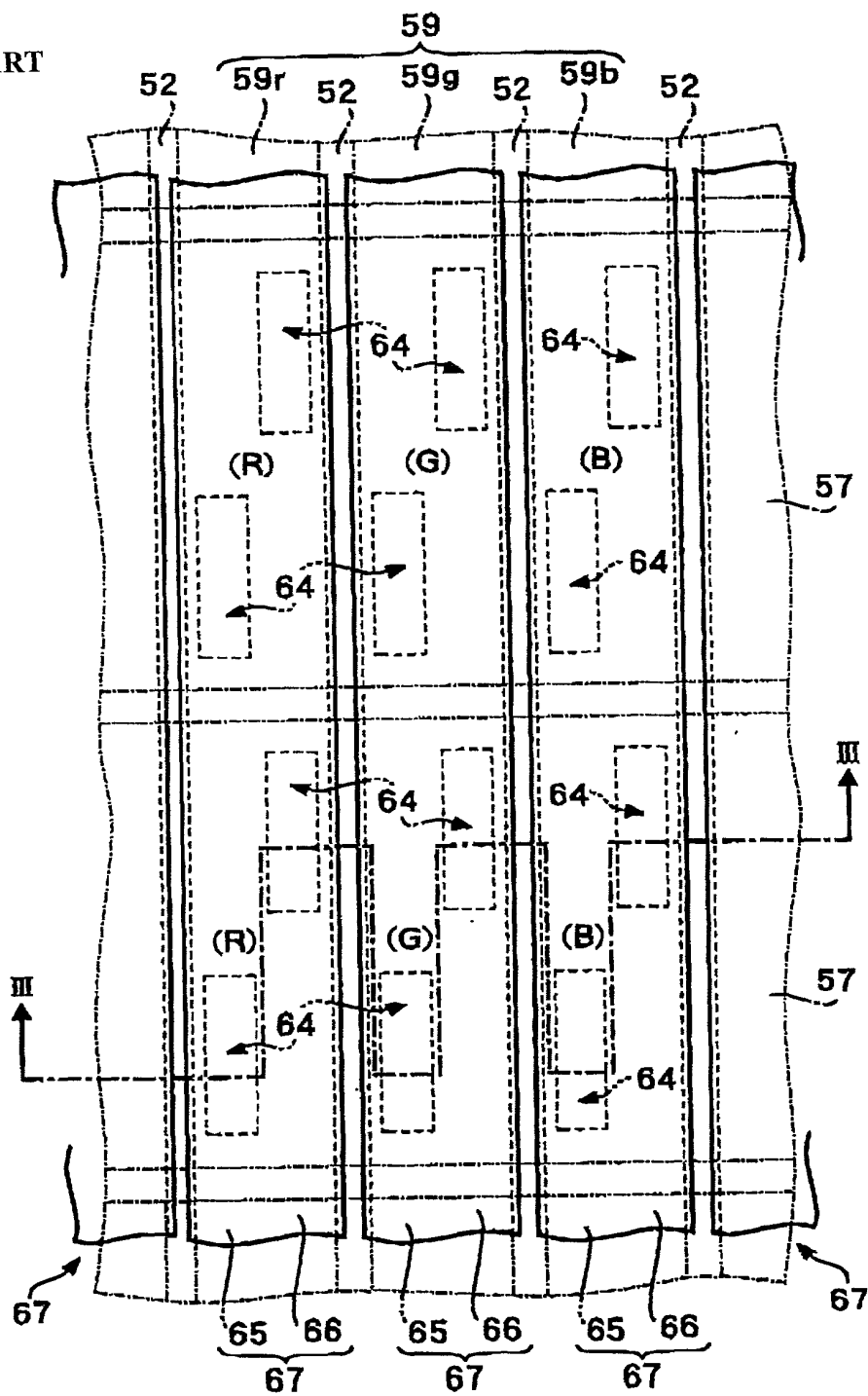


FIG. 9

PRIOR ART

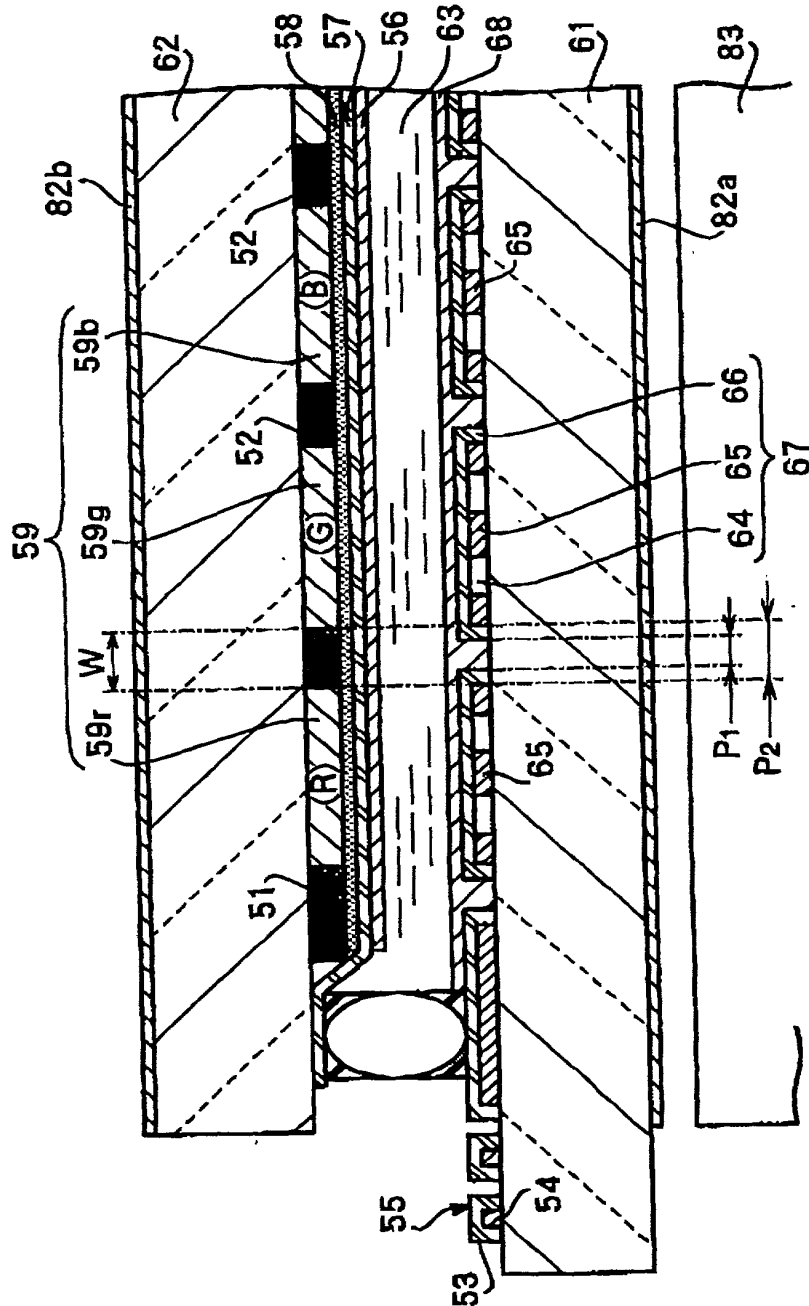


FIG. 10

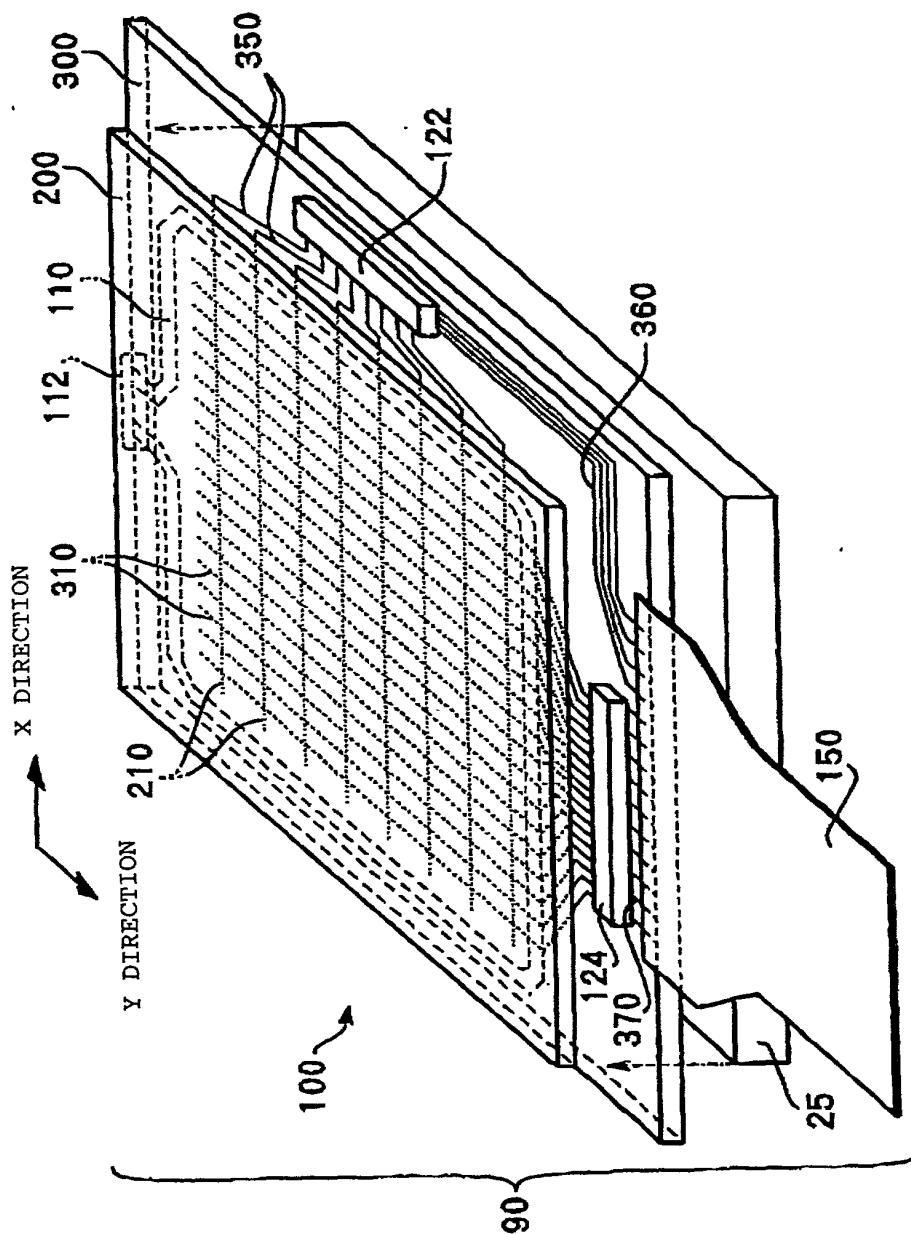
[illegible]

FIG. 11

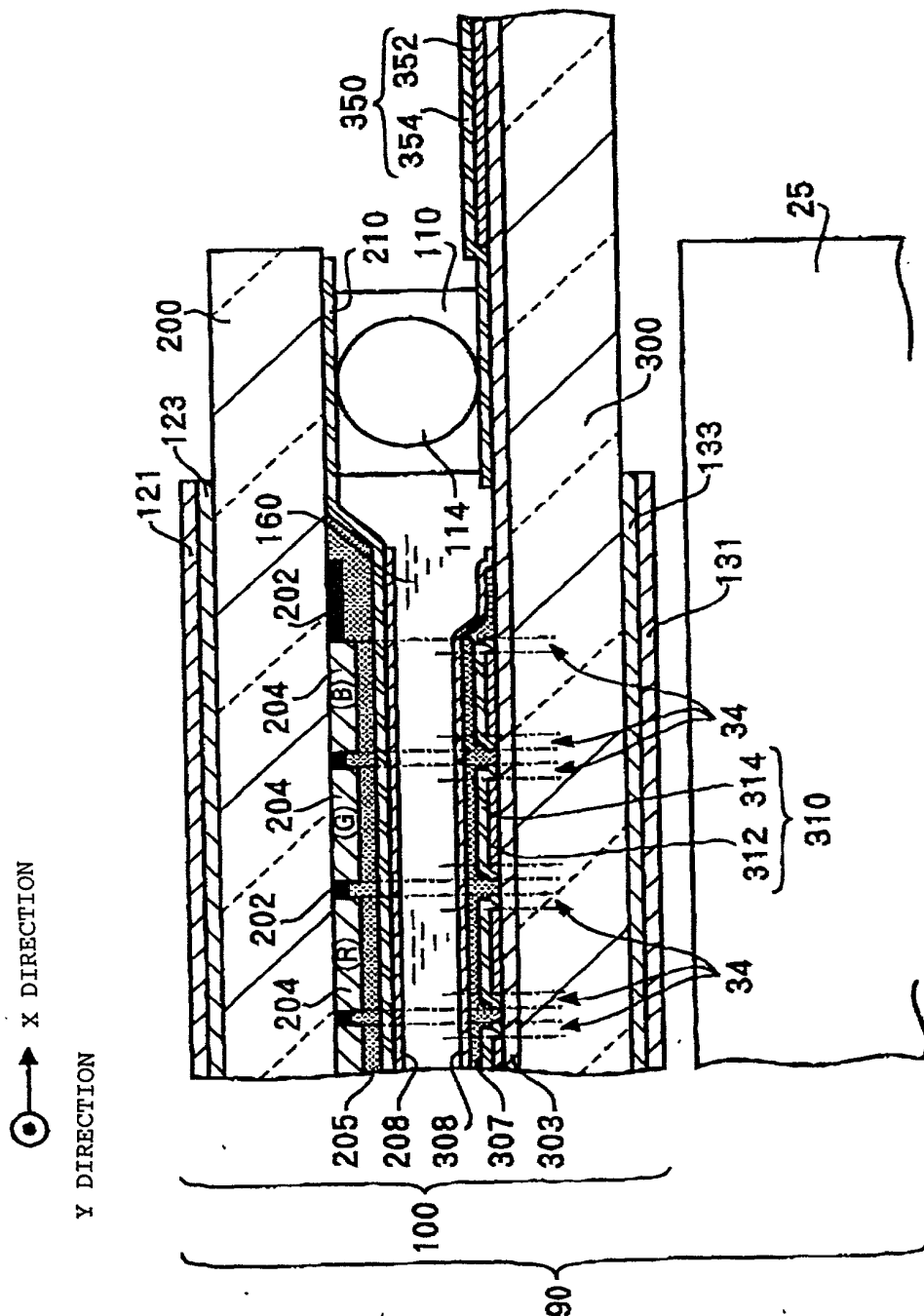


FIG. 13

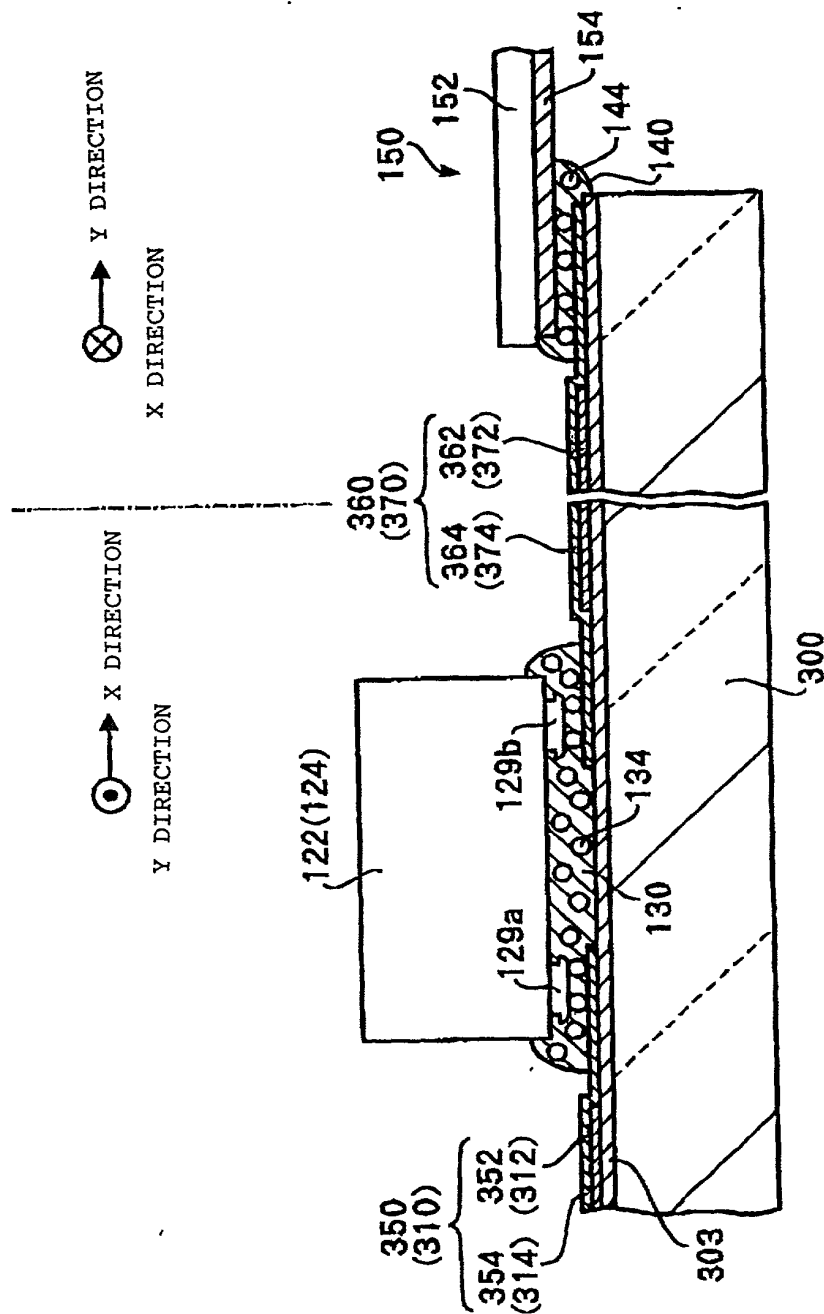


FIG. 14

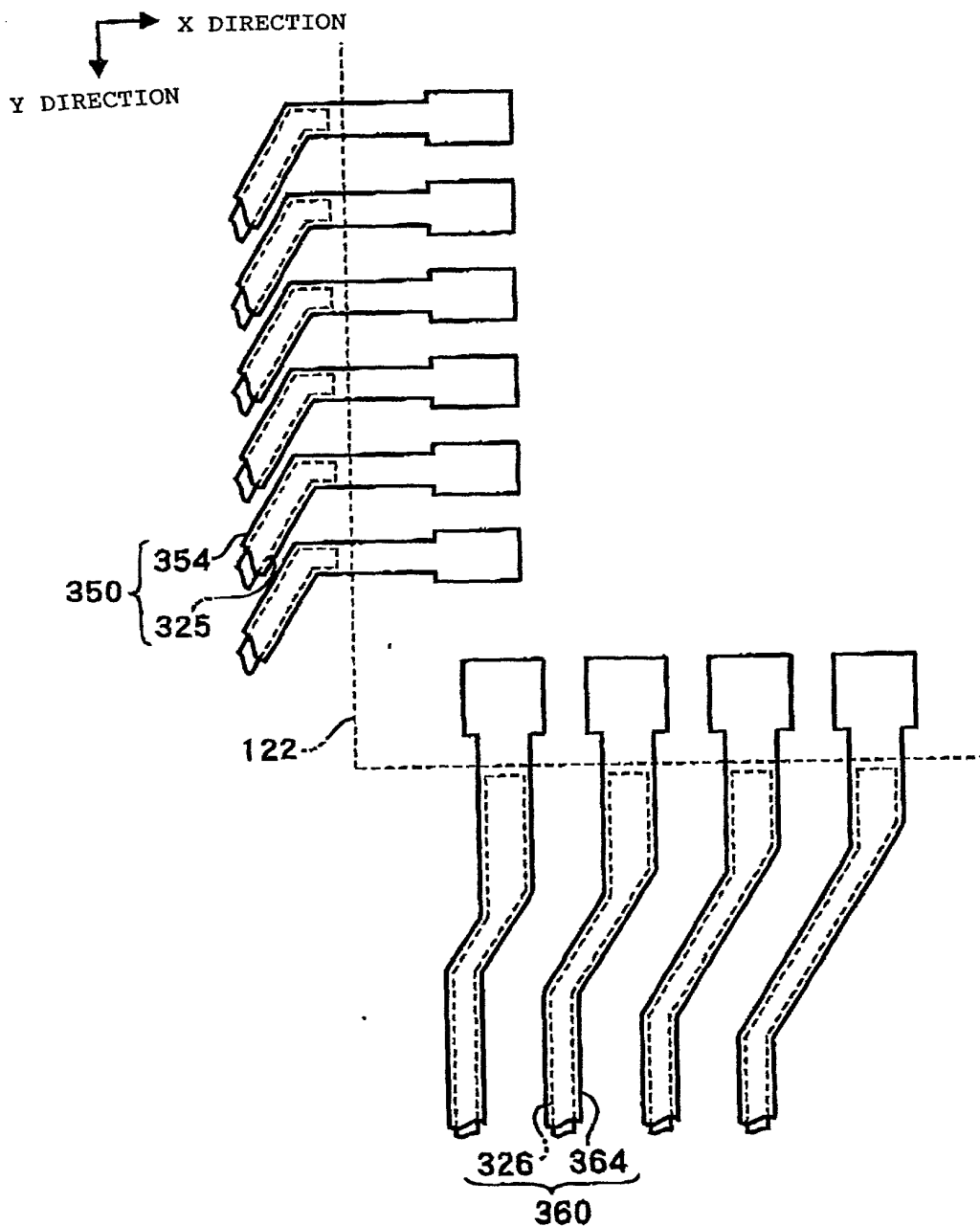


FIG. 15

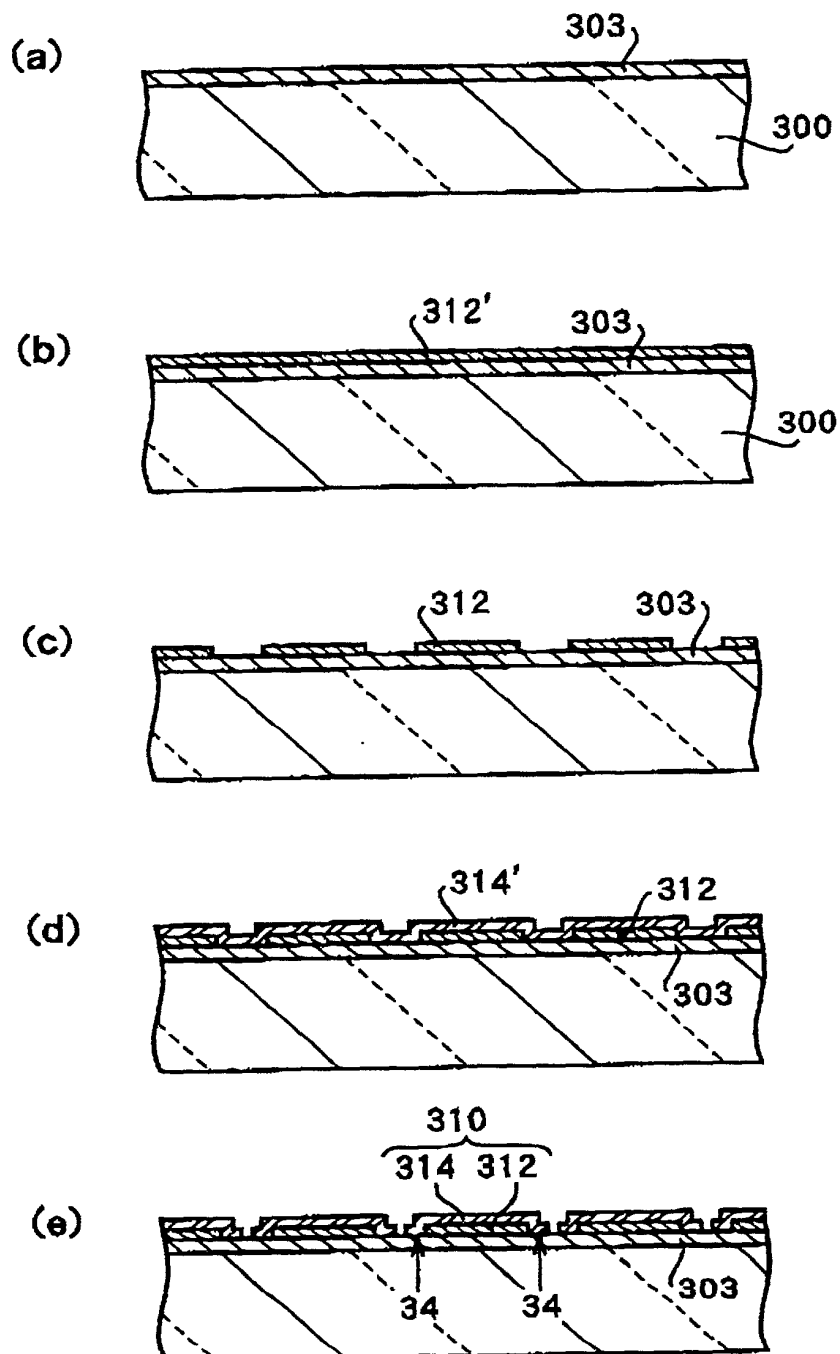


FIG. 16

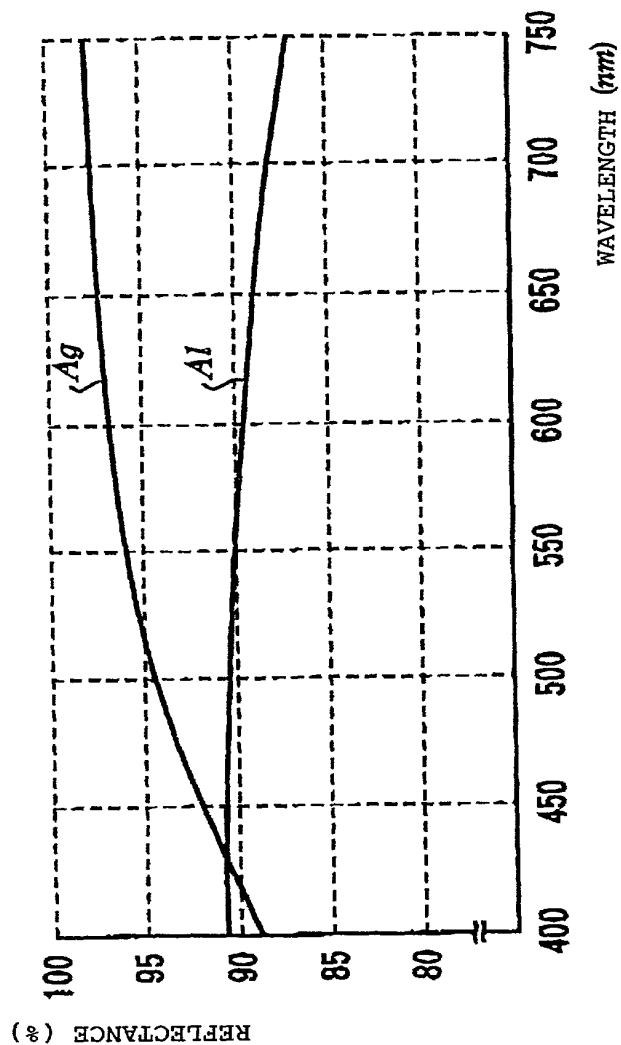


FIG. 17

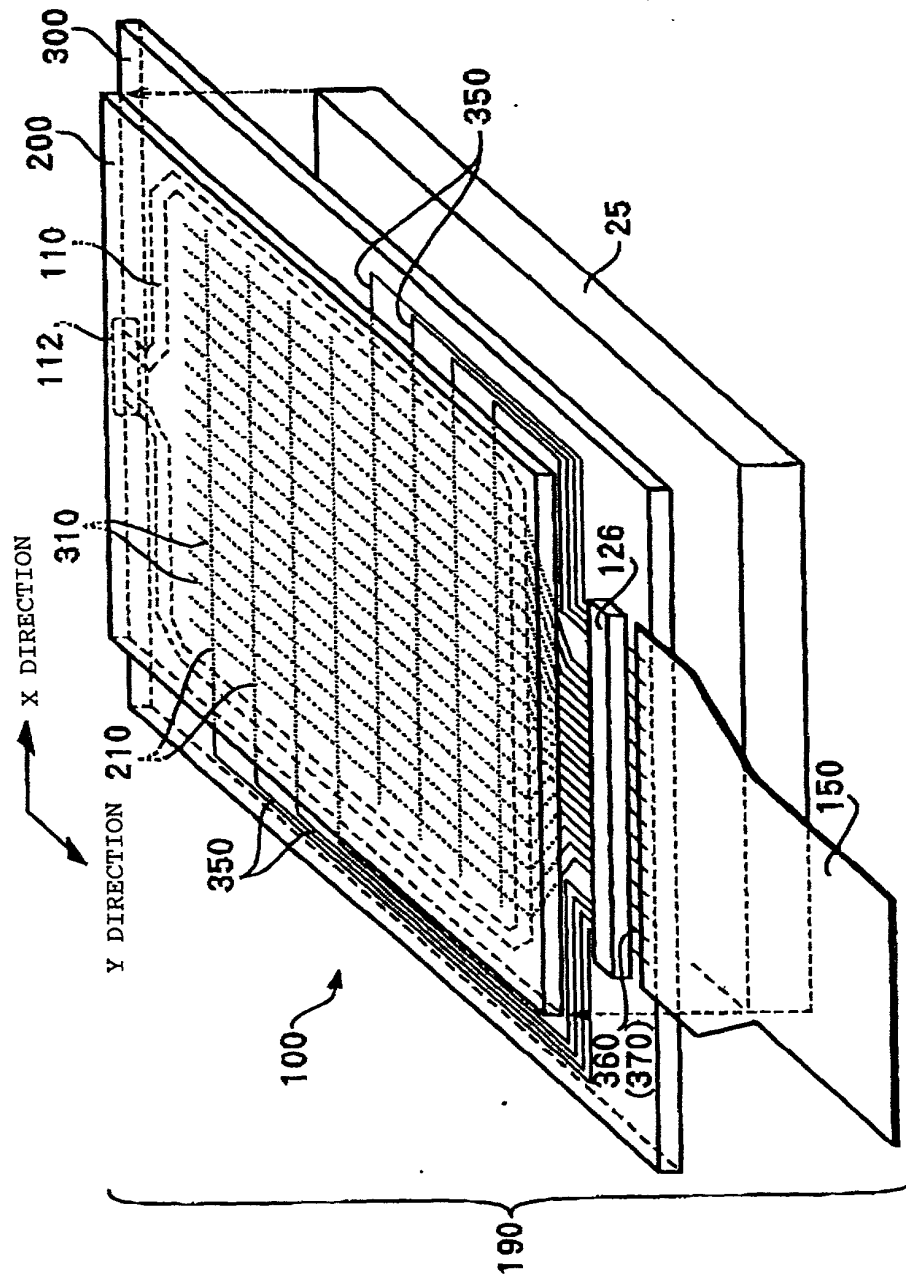


FIG. 18

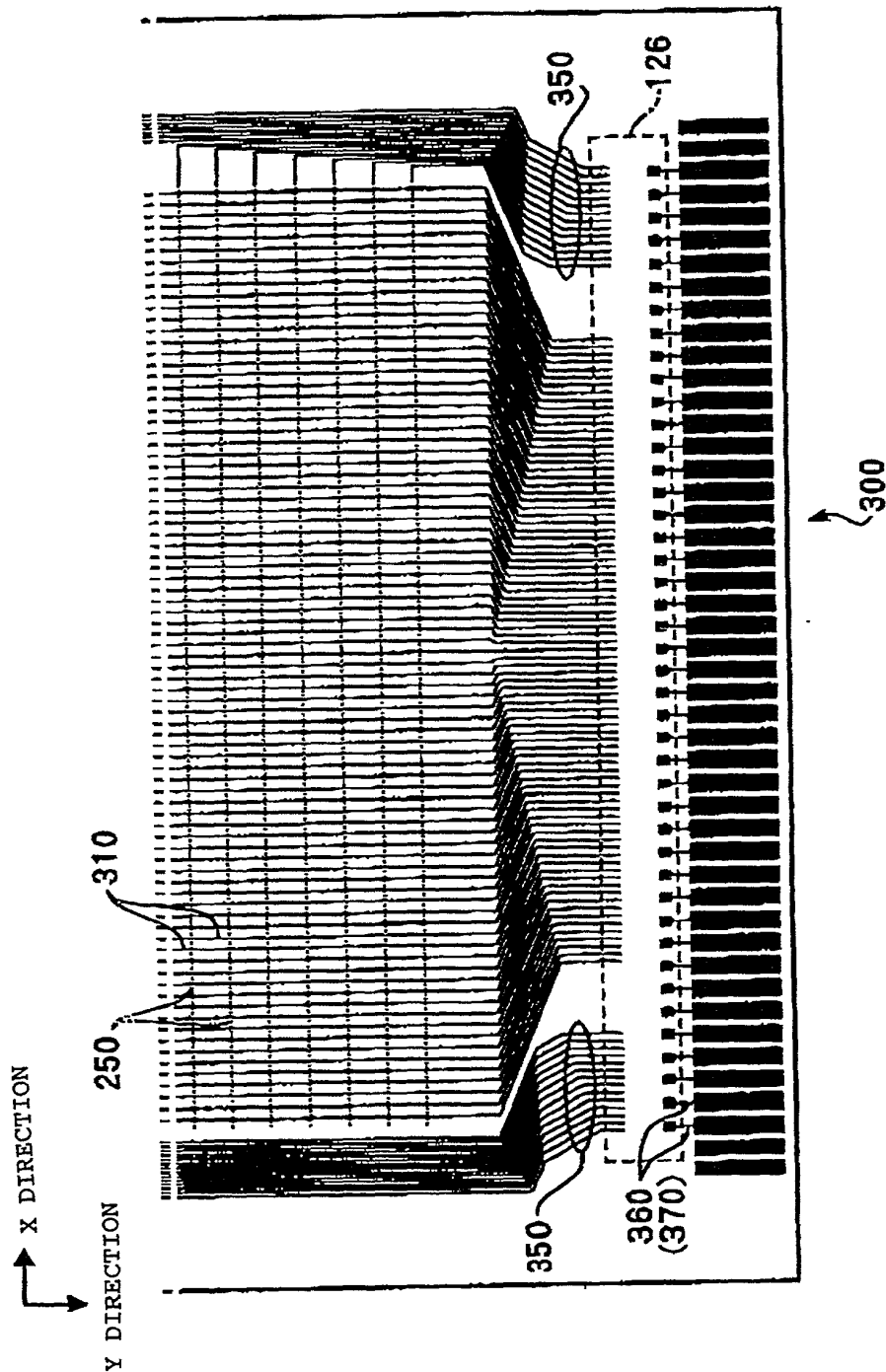


FIG. 19

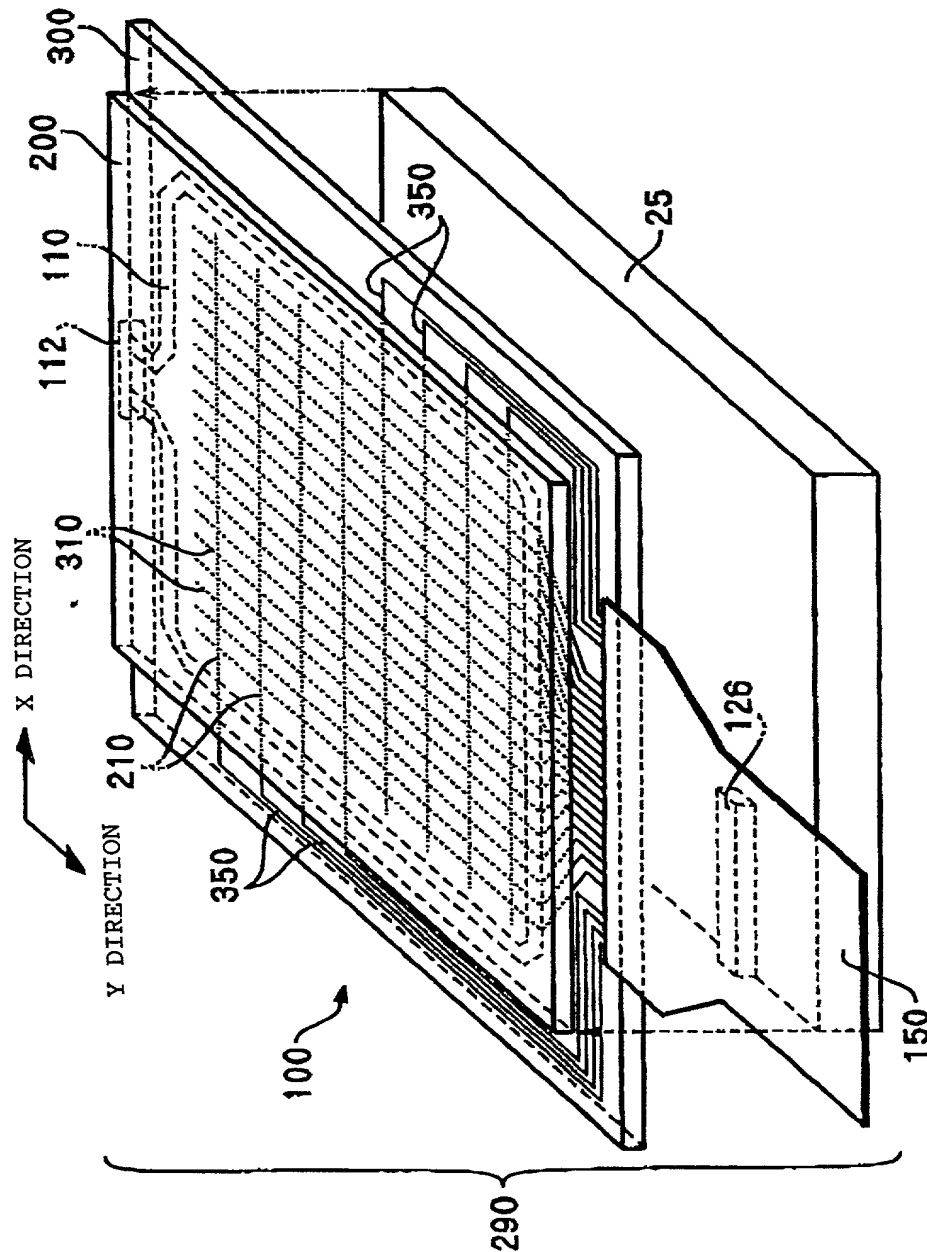


FIG. 20

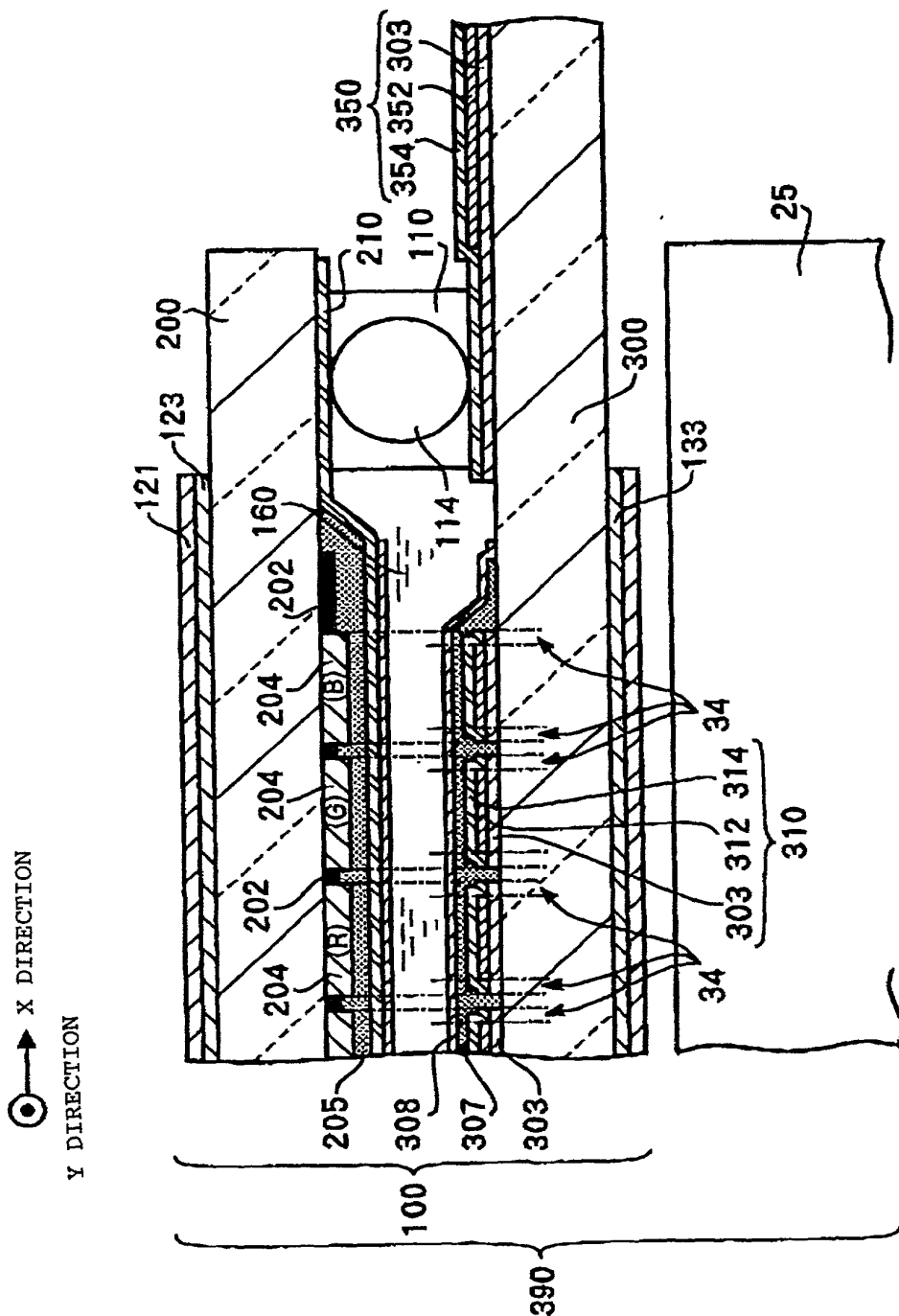


FIG. 21

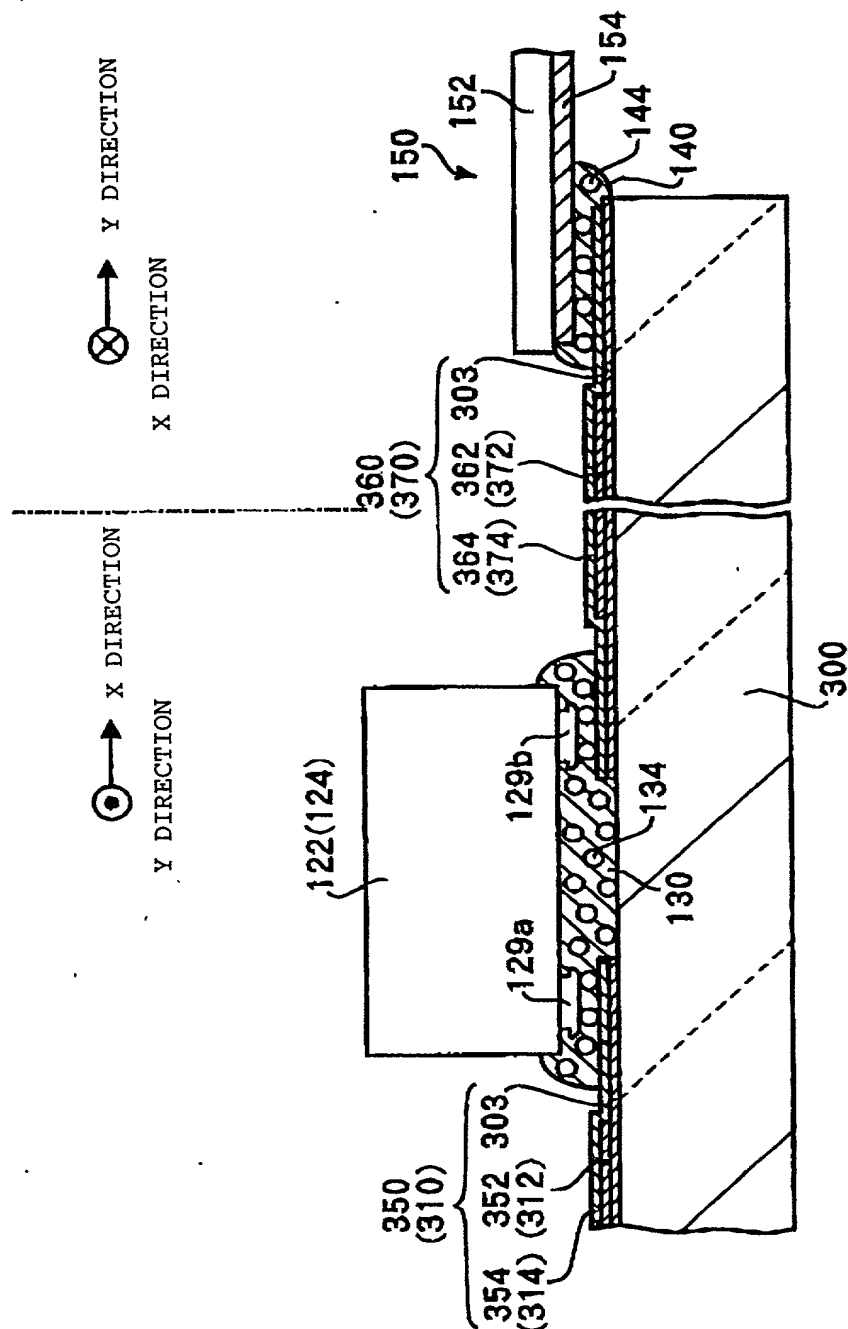
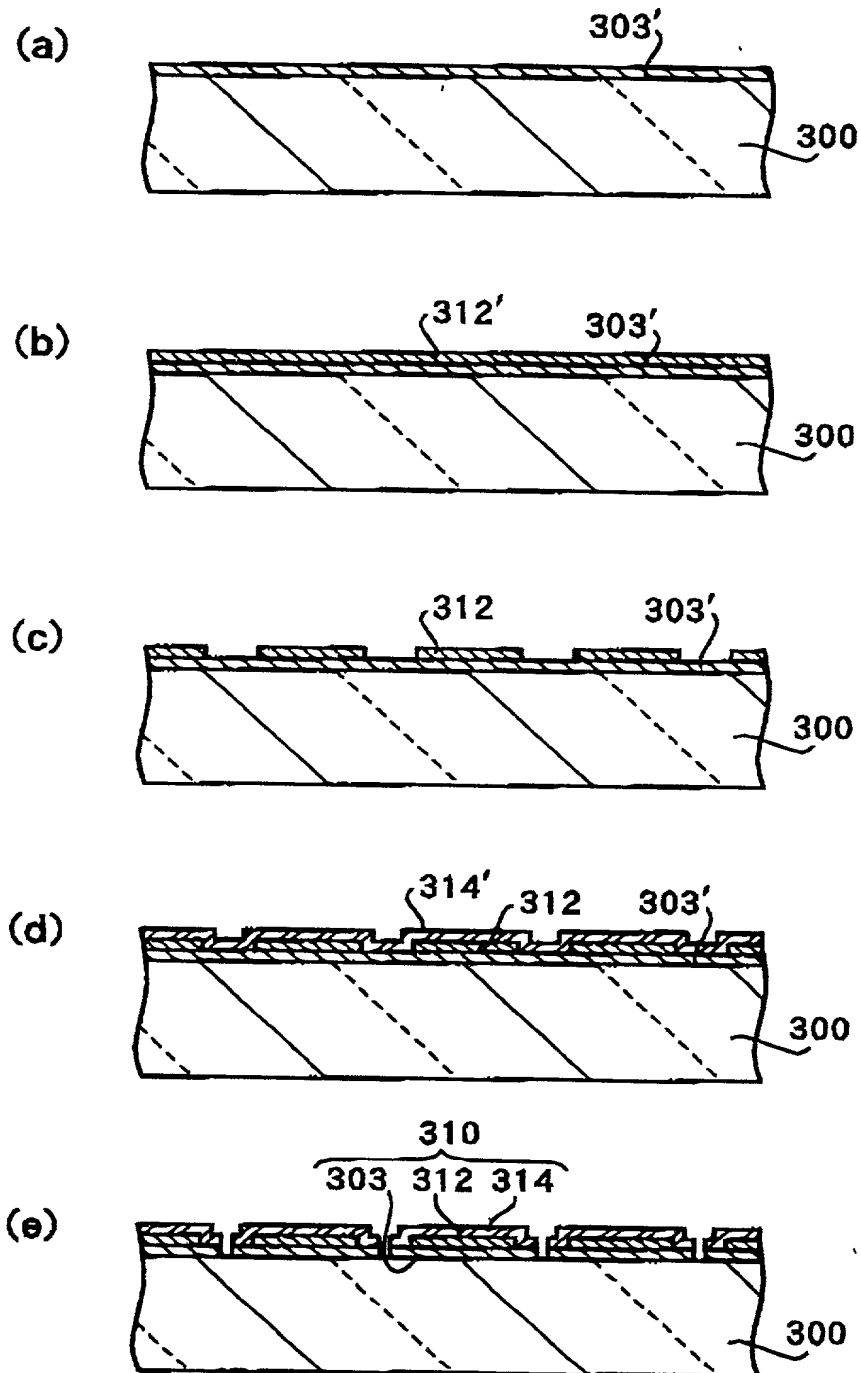


FIG. 22



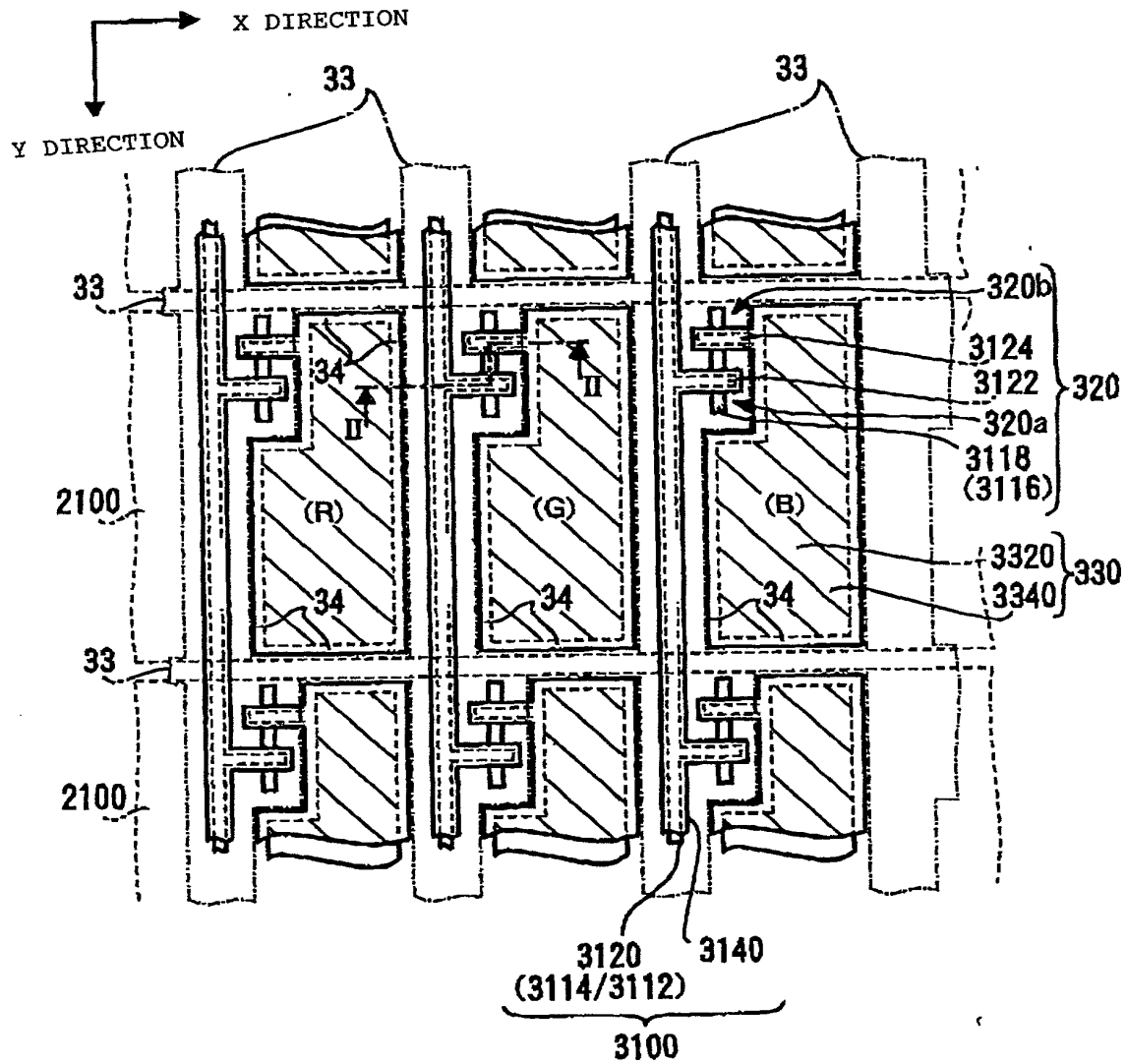


FIG. 24

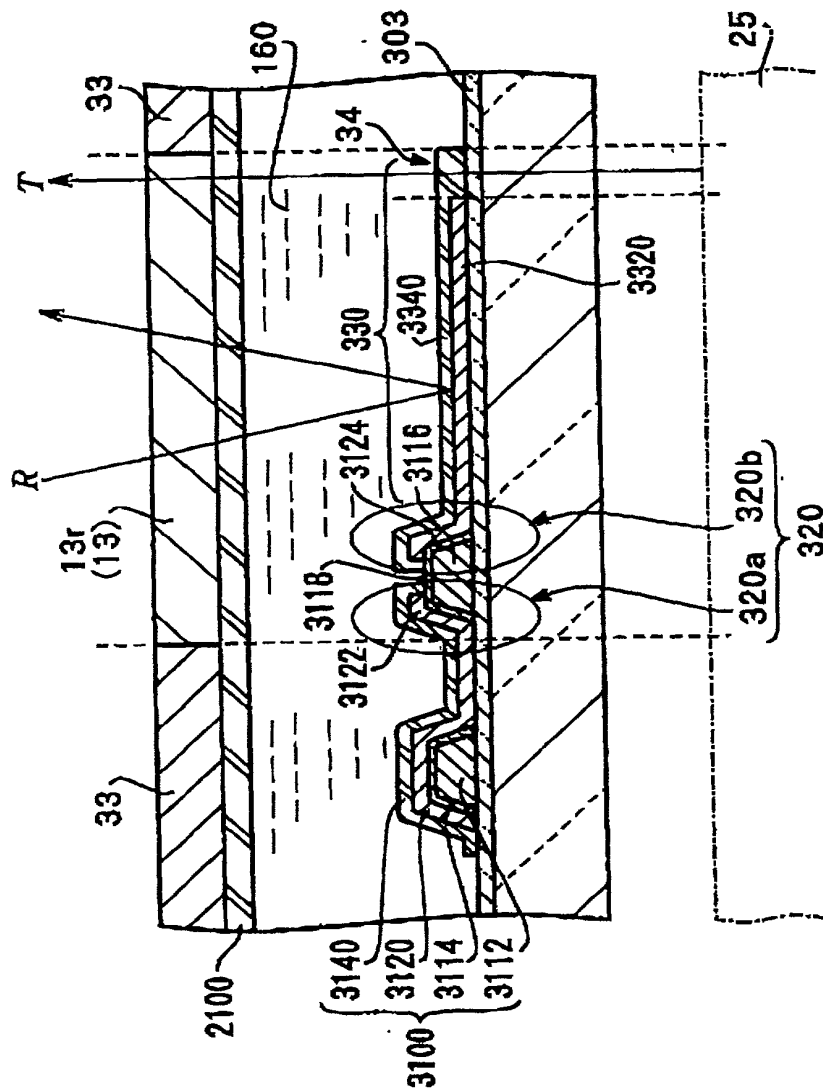
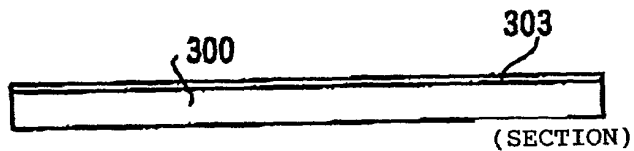
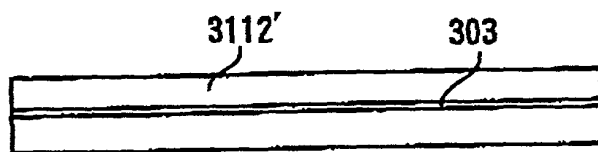


FIG. 25

(a) DEPOSITION OF UNDERLYING FILM



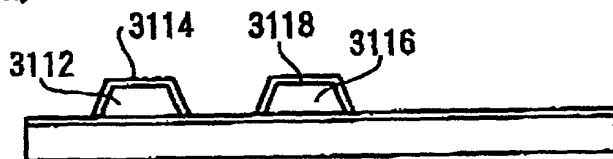
(b) DEPOSITION OF FIRST METAL FILM



(c) PATTERNING OF FIRST METAL FILM



(d) FORMATION OF INSULATING FILM BY ANODIZATION



(e) ELEMENT SEPARATION

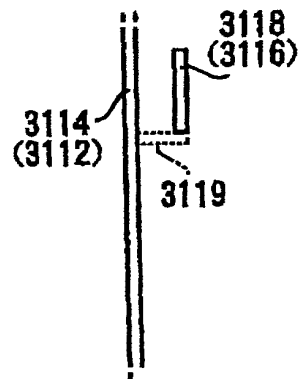
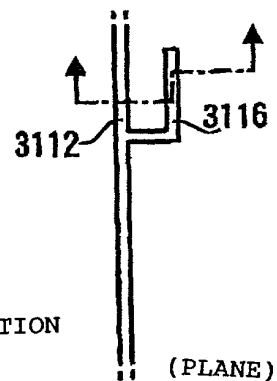
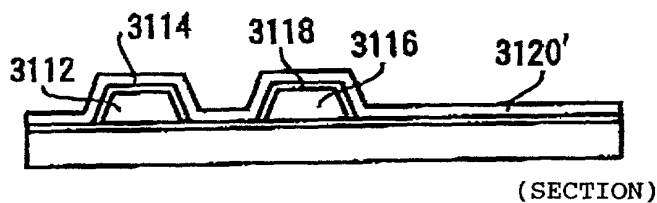
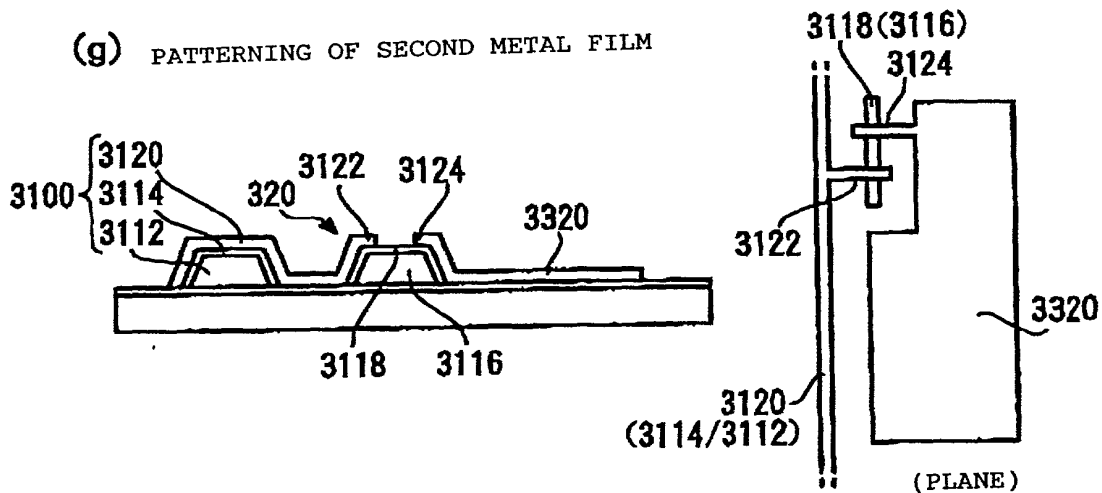


FIG. 26

(f) DEPOSITION OF SECOND METAL FILM (SILVER ALLOY)



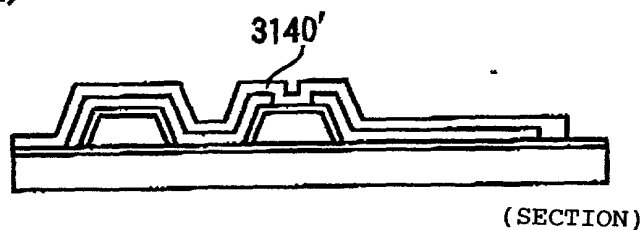
(g) PATTERNING OF SECOND METAL FILM



27/40

FIG. 27

(h) DEPOSITION OF ITO



(i) PATTERNING OF ITO

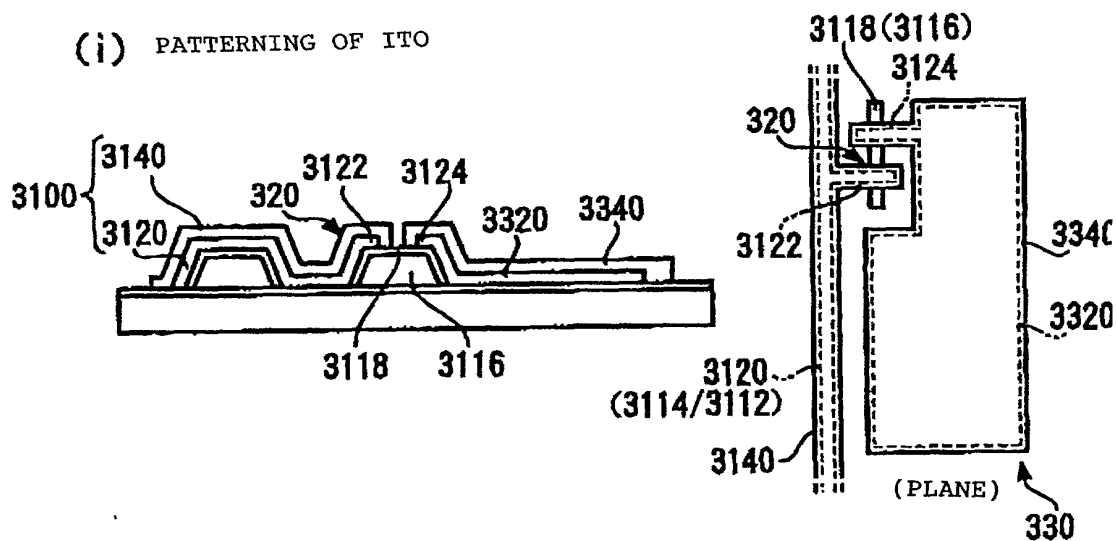
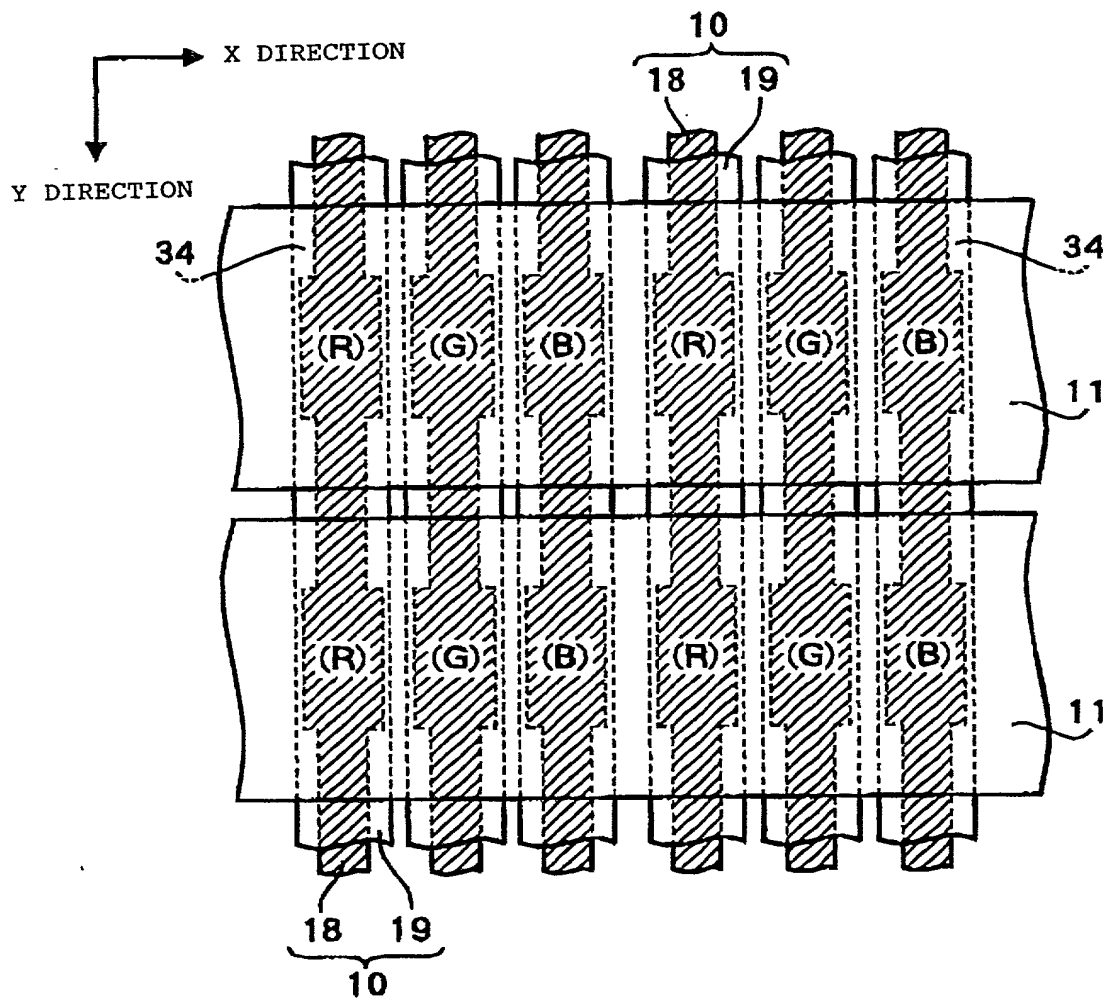


FIG. 28



10066304.020502

FIG. 29

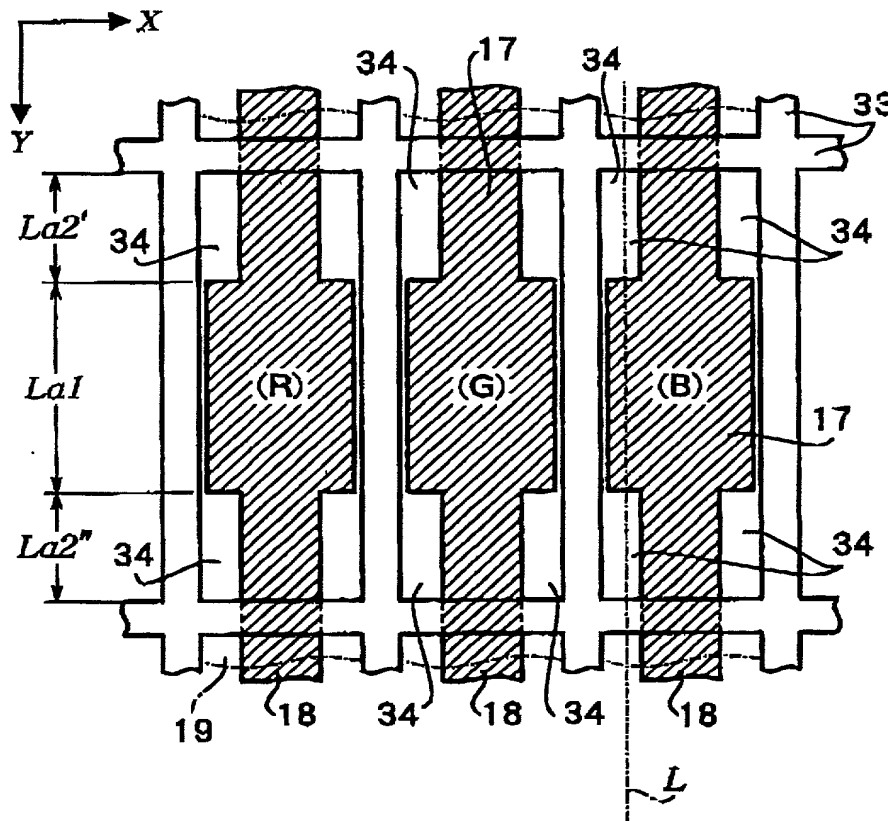


FIG. 30

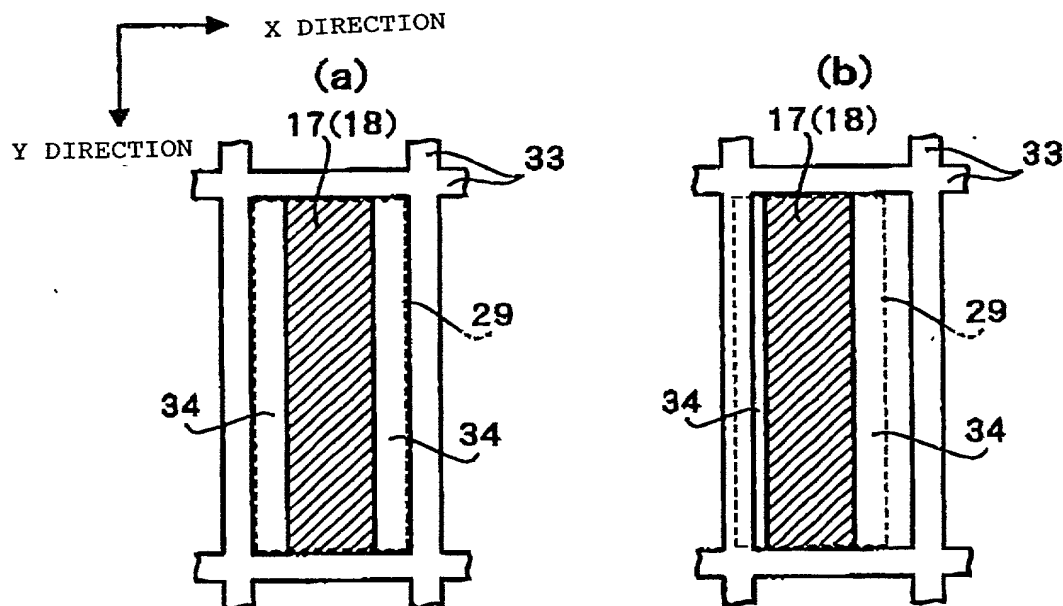


FIG. 31

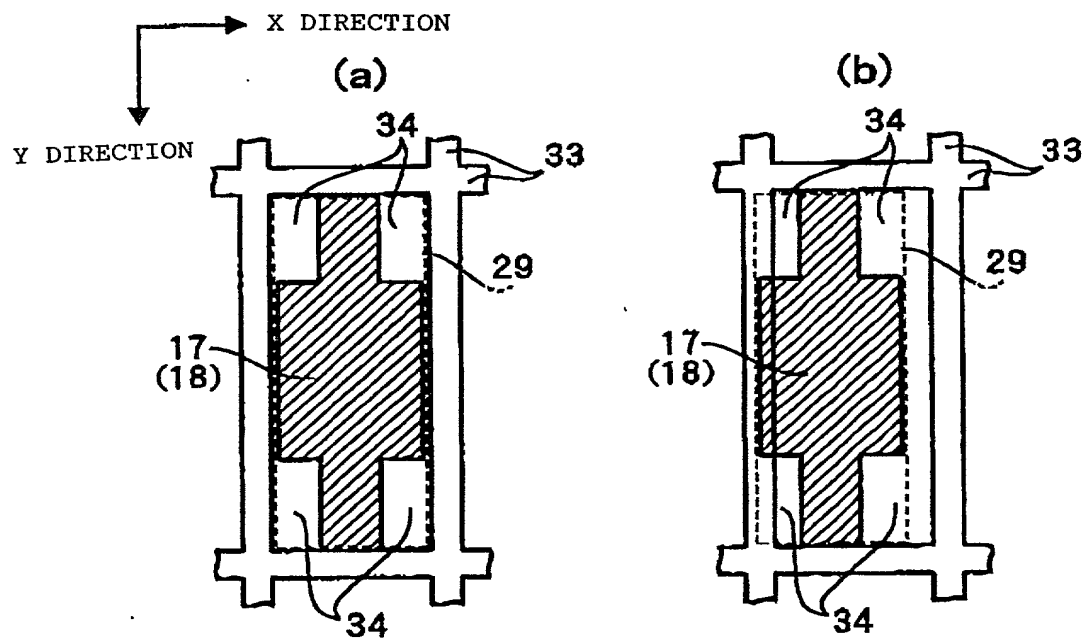
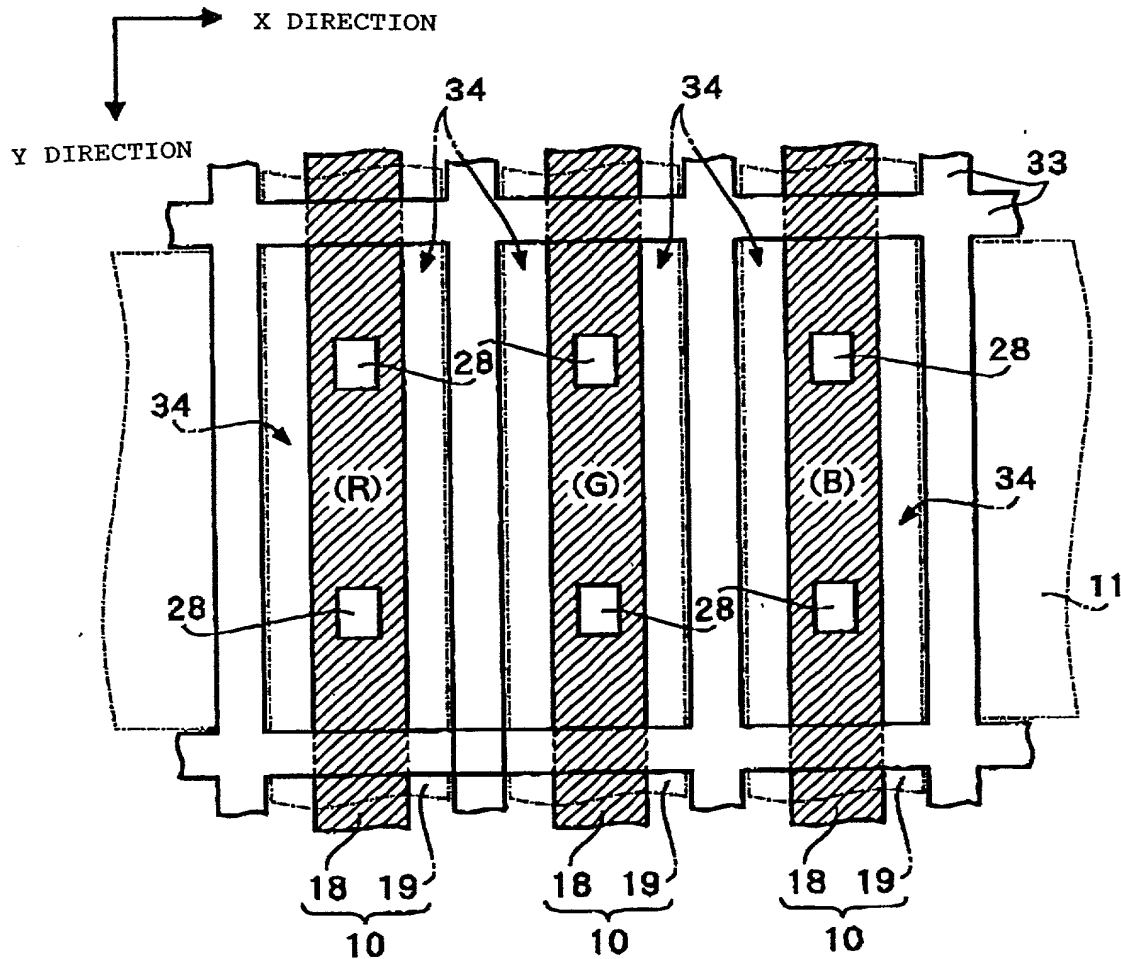


FIG. 32



33/40

FIG. 33

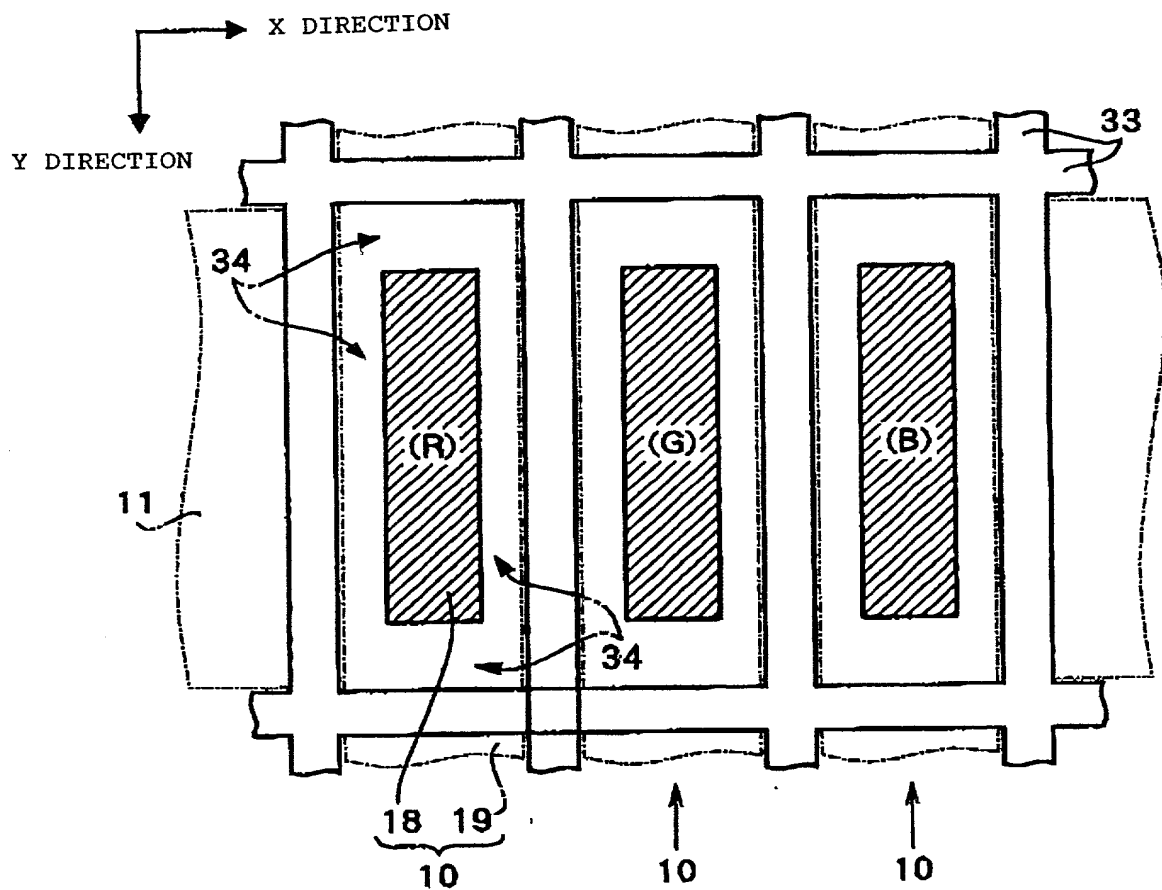
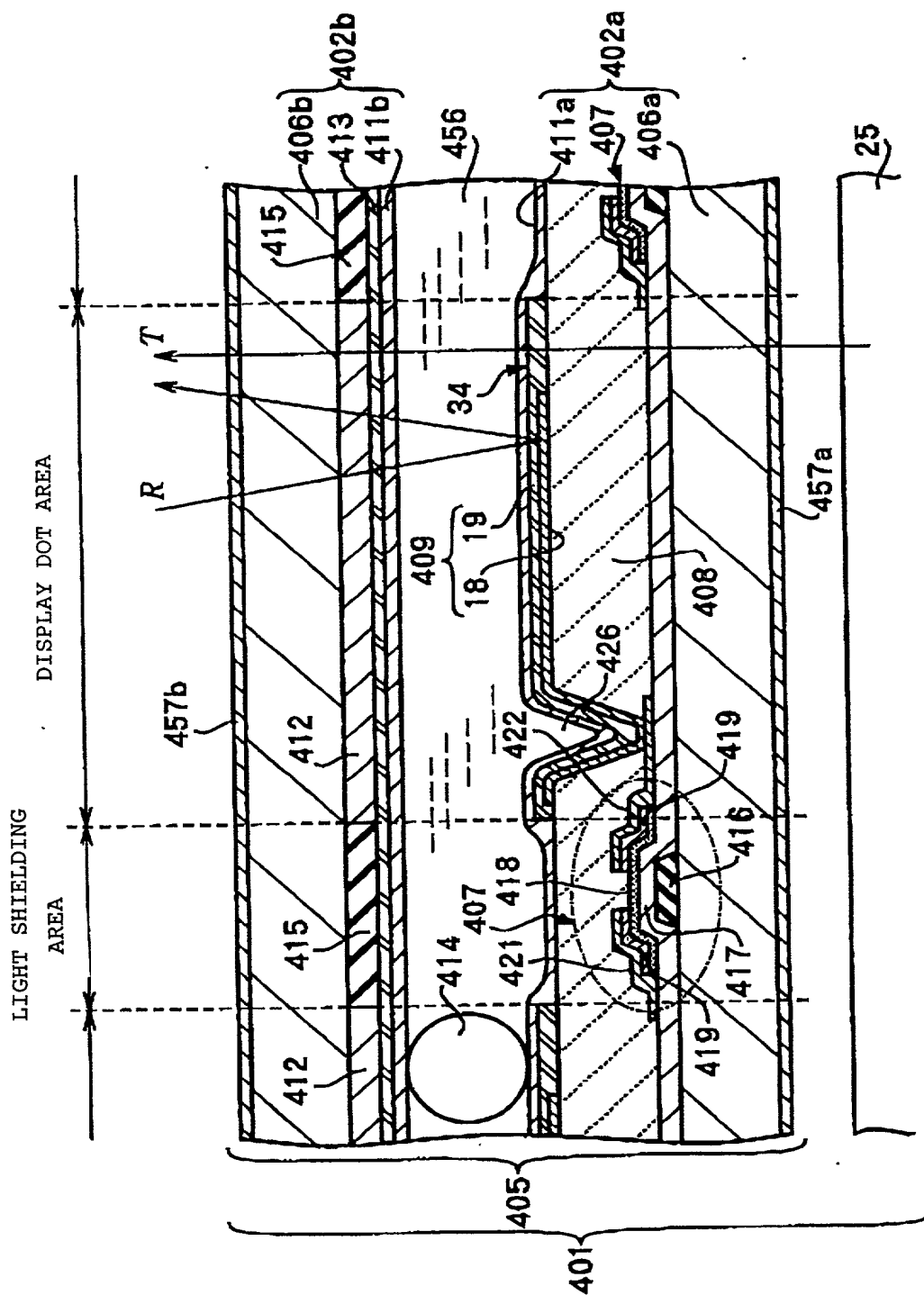
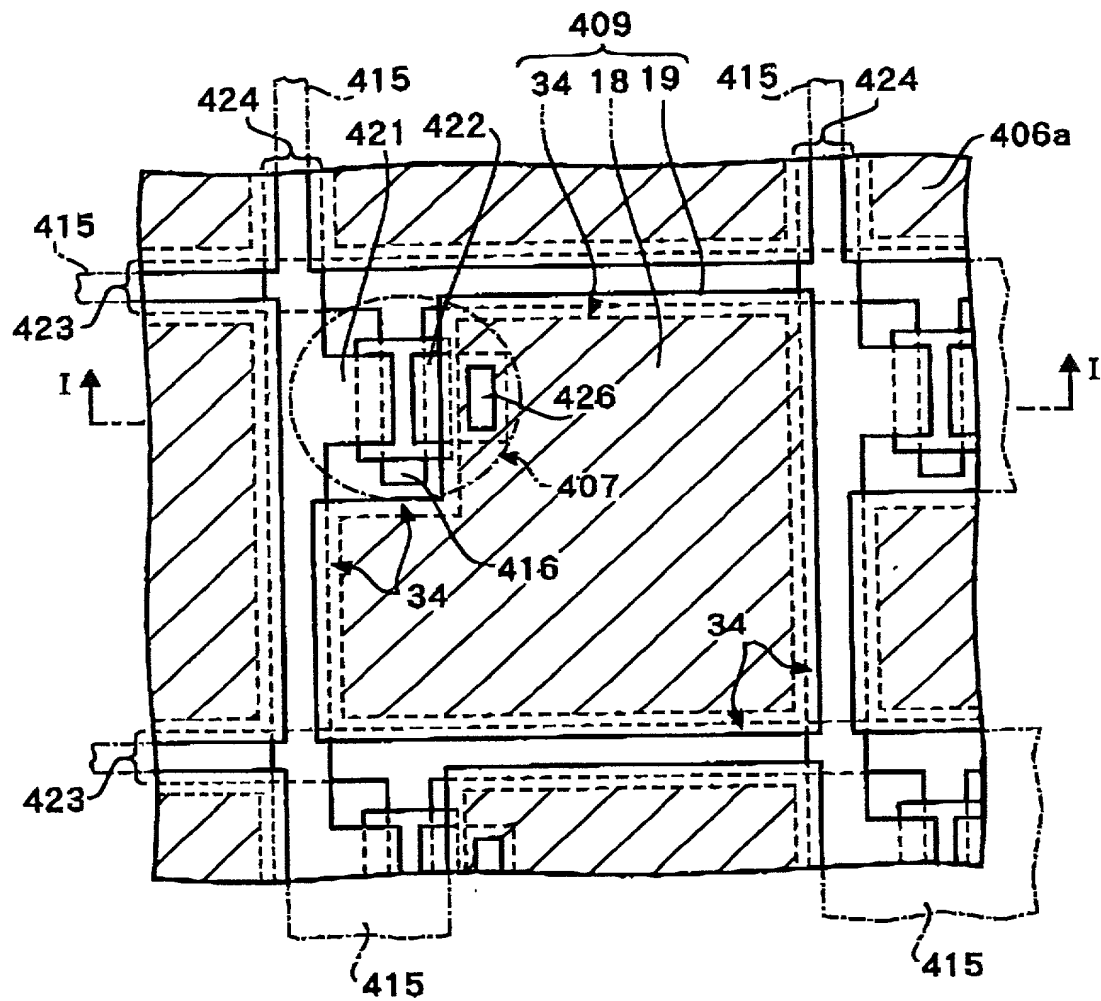


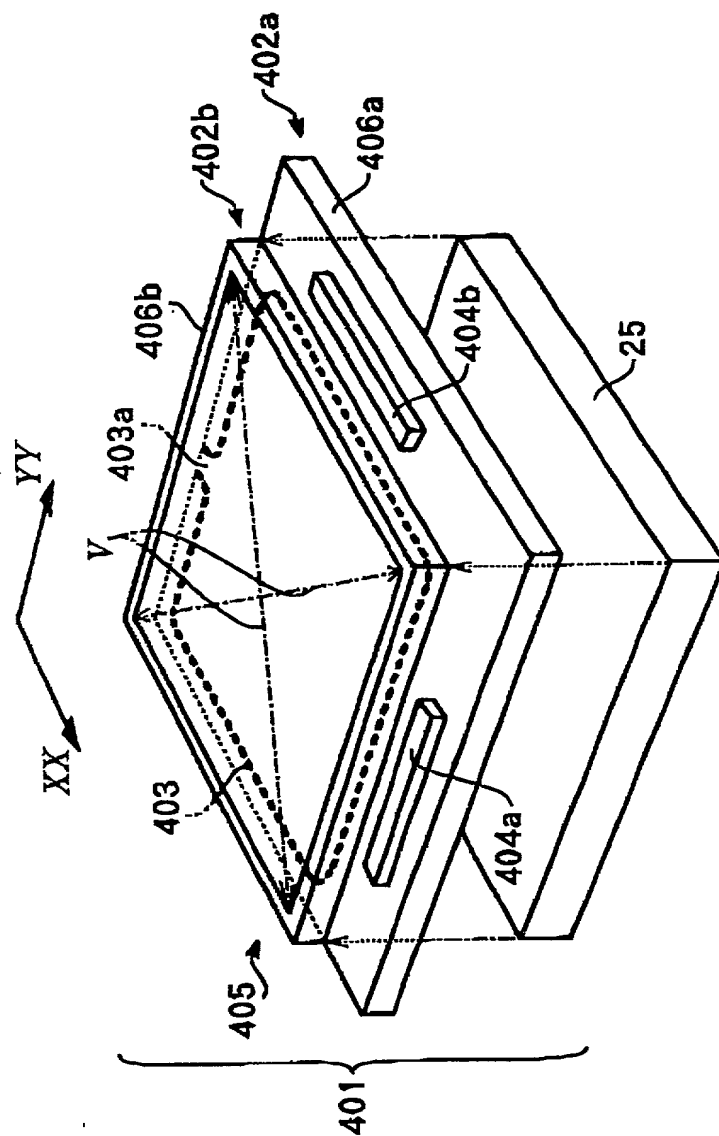
FIG. 34





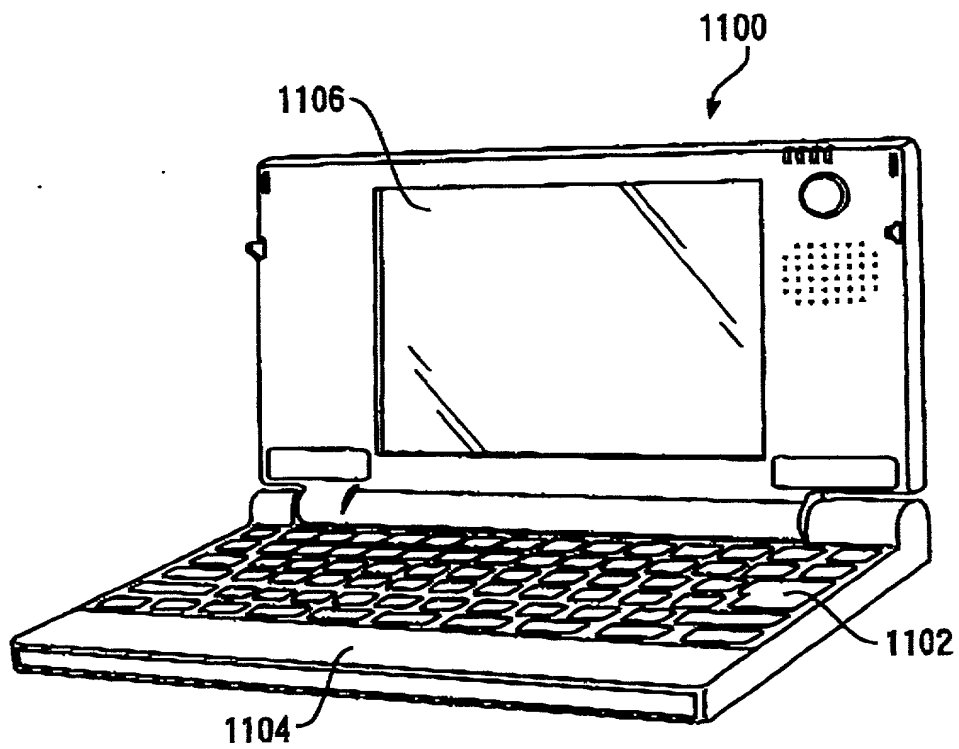
36/40

FIG. 36



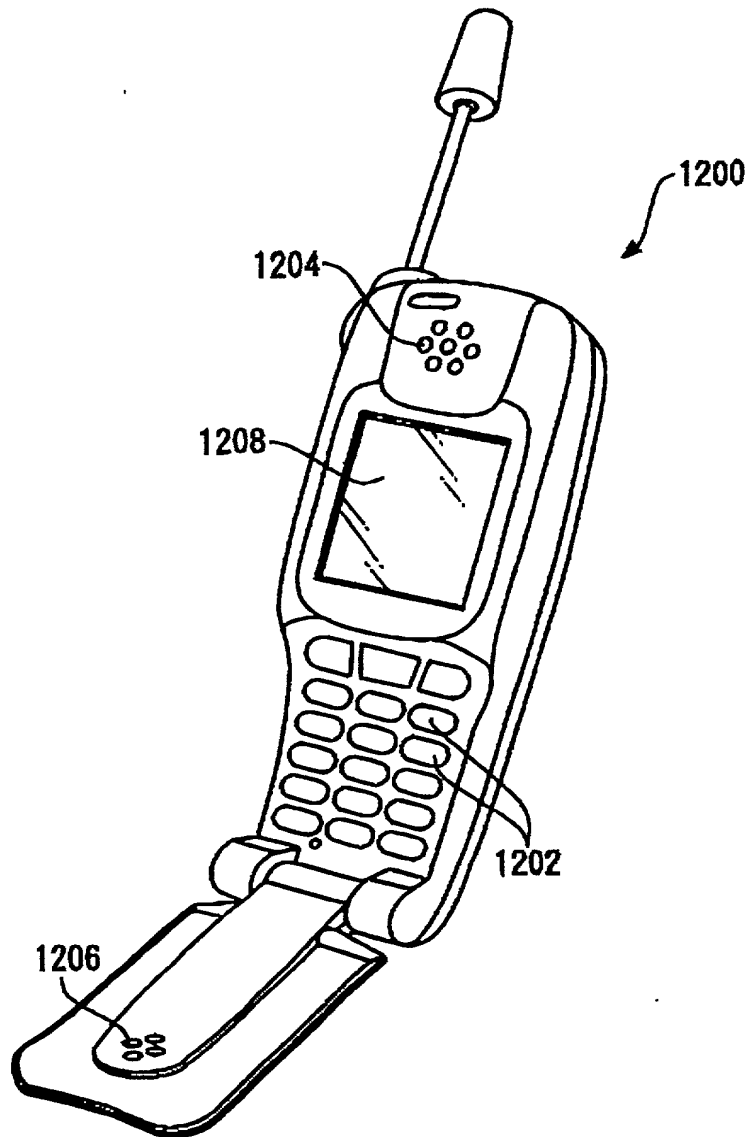
37/40

FIG. 37



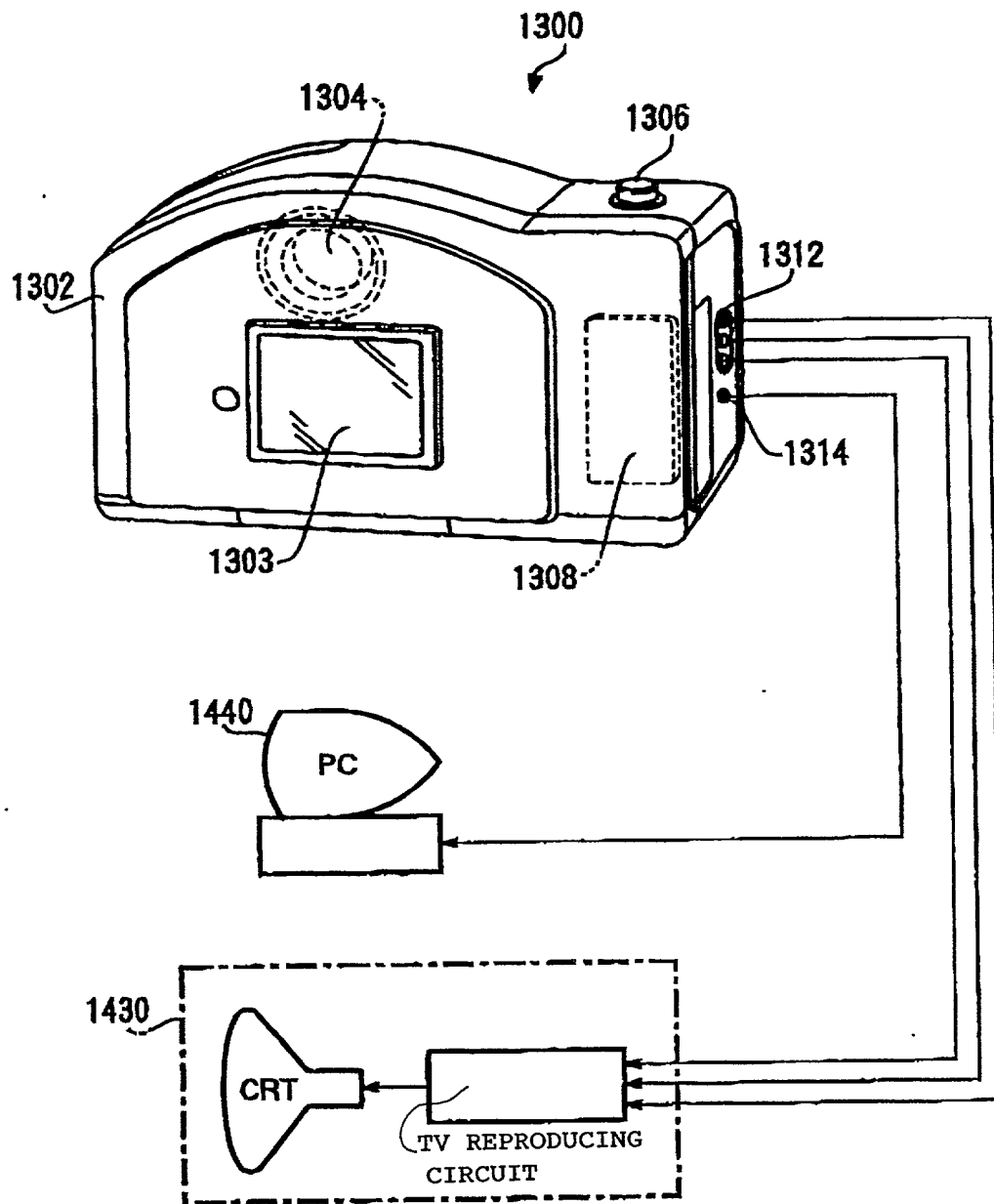
38/40

FIG. 38



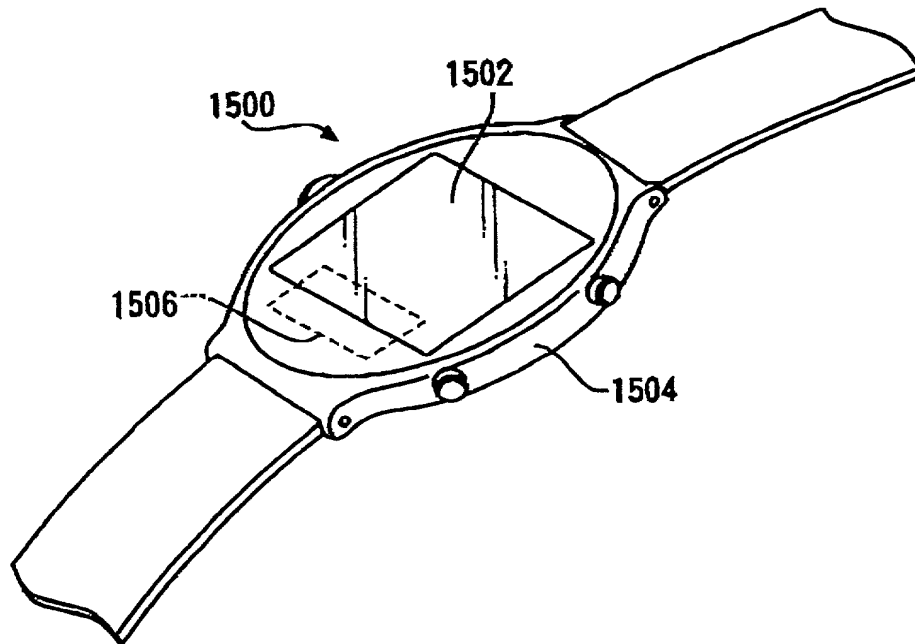
39/40

FIG. 39



40/40

FIG. 40



20050204089001